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NIST Database for the Simulation of Electron Spectra for Surface Analysis (SESSA)

Version 1.1

Users' Guide

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Version 1.0 of this database was released in December, 2005. Version 1.1 was released in December, 2006 with an enhancement to the Model Calculation screen that permits the user to display and save the zero-order partial intensities. Previously, a user had to go to another screen to perform these operations.

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1 INTRODUCTION

The objective of this database is to facilitate quantitative interpretation of Auger-electron and X-ray photoelectron spectra (AES/XPS) for surface analysis and to improve the accuracy of quantitation in routine analysis. For this purpose, the database contains physical data required to perform quantitative interpretation of an electron spectrum for a specimen with a given composition. Retrieval of relevant data is performed by a small expert system that queries the comprehensive databases. A simulation module [1, 16] is also available within SESSA that provides an estimate of peak intensities as well as the energy and angular distribution of the emitted electron flux (see Section 4.9). The information needed by the expert system to accomplish its task closely matches instrument settings made by an experimenter when actually performing a measurement and is complemented by an initial estimate of the sample composition.

SESSA can be used for two main applications. First, data are provided for many parameters needed in quantitative AES and XPS (differential inverse inelastic mean free paths, total inelastic mean free paths, differential elastic-scattering cross sections, total elastic-scattering cross sections, transport cross sections, photoionization cross sections, photoionization asymmetry parameters, electron-impact ionization cross sections, photoelectron lineshapes, Auger-electron lineshapes, fluorescence yields, and Auger-electron backscattering factors). Second, Auger-electron and photoelectron spectra can be simulated for layered samples. The simulated spectra, for layer compositions and thicknesses specified by the user, can be compared with measured spectra. The layer compositions and thicknesses can then be adjusted to find maximum consistency between simulated and measured spectra. The design of the software allows the user to enter the required information in a reasonably simple way. The modular structure of the user interface closely matches that of the usual control units on a real instrument. In other words, any user who is familiar with a typical electron spectrometer can perform a retrieval/simulation operation with the SESSA software in a few minutes for a specimen with a given composition.

Section 3 familiarizes the user with some special features of the software. These features include a separate window for graphical representation of a selected physical quantity that is fully controllable by the user (see Section 4.2), a popup menu showing the reference to the literature for each retrieved datum, an on-the-fly database selection popup menu and, last but not least, the fully parallel operation of the graphical user interface (GUI) and the command line interpreter (CLI).

Section 4 presents a detailed and comprehensive description of the functionality of the software. The sources for the physical data in SESSA

as well as the simulation algorithm are described in Section 6, and finally, Section 7 highlights some of the key features of the software with the aid of a few tutorials that are contained in this package in the form of CLI command files.

2 GETTING STARTED

2.1 Packet Content

CD-ROM
Users' guide

2.2 System Requirements

The software has been tested to run on a personal computer with the Windows 95, Windows 98, Windows NT, Windows 2000, and Windows XP operating systems. The CD also contains MacIntosh OS X and LINUX versions of the software. These versions have been tested to run on these platforms but have not been as extensively tested as the Windows versions. They are included here as unsupported software. The authors nevertheless welcome bug-reports, suggestions and comments on this software (as described in Section 8).

The databases and software need approximately 180 MB of disk space. The minimum amount of RAM required to run the program amounts to about 15 MB. The exact amount of RAM needed depends on the type of problem under study. When a simulation is performed, the minimum required RAM increases to 30 MB. When simulations are performed for large-scale complex problems (see Section 4.9), memory usage can increase even further.

2.3 Installation

Insert the CD-ROM into the CD-ROM drive, click on the icon titled SESSA_setup.exe and follow the instructions.

3 SPECIAL FEATURES OF SESSA

SESSA contains a number of databases containing information concerning excitation and transport of signal electrons (Auger electrons and photoelectrons) in solids. These databases are queried by a small expert system that retrieves all information needed for the interpretation of experimental results. The expert system needs a specification of the expected sample structure and of the experimental procedure, and will then retrieve physical data relevant to the specified experiment. If desired, a simulation is performed of the specified experiment. The sample

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composition is specified by providing the thickness and composition for each of a number of layers.

Two alternative methods are provided for user interaction with SESSA: a graphical user interface (GUI) and a command line interface (CLI). These interfaces operate in parallel: the action taken by SESSA is determined by the commands received by the CLI but does not depend on the way the command was generated. The CLI can process commands produced in three different ways: (1) commands typed on the CLI console; (2) a single command or a series of commands read from a file; and (3) commands generated by the GUI. Some of the general features of the CLI and the GUI are described in this Section to familiarize the user with the operation of the software. A detailed description of the software functionality and user interaction can be found in Section 4. Representation of several data types in the software is discussed in Section 3.3, and the ouput produced by SESSA is described in Section 3.4.

The notation used in this Chapter uses the following conventions: GUI commands are enclosed in quotation marks (") while CLI `COMMANDS` and `filenames` are set in a different font.

3.1 The graphical user interface (GUI)

The main menu of SESSA is shown in Fig. 3.1. The GUI in SESSA is organized by means of a number of submenus that can be reached via the main menu in the usual way. The available submenus and their shortcut commands are shown in Table 3.1. In each menu, data for a number of quantities are on display and can be manipulated by the user. For a detailed description of the purpose of these menus, see Section 4.

Figure 3.1. The main menu of SESSA.

Apart from the usual components of a typical GUI, SESSA also provides a graphical display of certain quantities. For example, press CTRL-3 for a graphical representation of the differential elastic cross section and differential inverse inelastic mean free path. These displays cannot be changed in any way by the user. By double clicking on any of these displays, however, an additional plot window is opened that allows full user access to the display variables by means of a right mouse click (see

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Section 4.2). This plot window can also be opened from within the CLI by an appropriate command.

Table 3.1. (Sub) menus of the GUI and their shortcut commands.

Project		Project (Main) menu
Sample: layers	CTRL-1	Sample Composition
Sample: peak	CTRL-2	Parameters concerning signal electron generation
Sample: parameters	CTRL-3	Parameters concerning signal electron transport
Experiment: source	CTRL-4	Source of exciting radiation
Experiment: geometry	CTRL-5	Geometrical configurations
Experiment: spectrometer	CTRL-6	Spectrometer settings
Model	CTRL-7	Model Calculations
Database	CTRL-8	Selection of default databases for all relevant quantities
CLI Console	CTRL-9	User interaction via the command line interface (CLI)
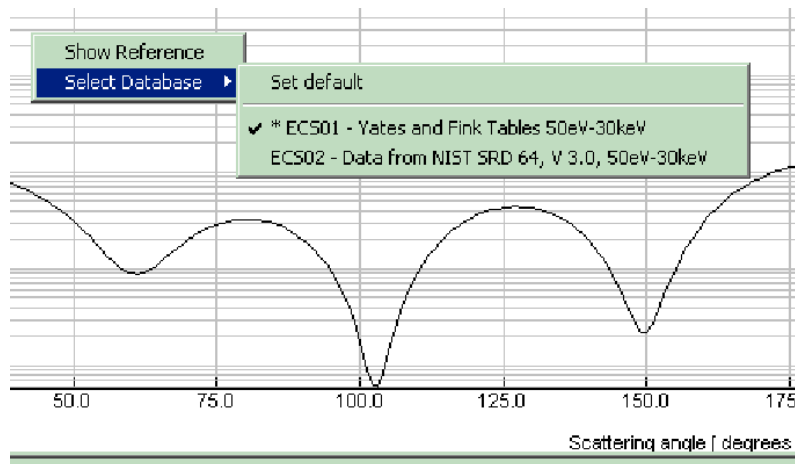
Figure 3.2. Example of a database selection popup menu.

Two special features of SESSA are the traceability of the data and the on-the-fly selection of databases. By means of a right mouse click on a numerical value retrieved from a database, or on the corresponding graphical display, a menu pops up that offers two choices: either to

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activate the reference dialog or to activate the on-the-fly database selection menu (see Fig. 3.2). If the latter is selected, the user can choose between the different databases that are available for the quantity in question. Alternatively, the user can reset the choice of the database to the default database, i.e., the database that has been selected in the database defaults menu (see Section 4.8). Since not every database in SESSA is extensive, in that it contains a datum for a given quantity for any arbitrary element, energy subshell, etc., it may happen that the requested datum is not returned by the selected database. In such cases, the expert system automatically queries the other databases available for the quantity in question. In this way, at least one of the databases contains a value or a credible estimate for the requested datum. In some cases, this "backup" database will rely on a theoretical or semi-empirical expression to predict the desired quantity. In the database selection popup menu, the database selected by a user is indicated by √ while an asterisk indicates that the database was successfully queried (see Fig. 3.2).
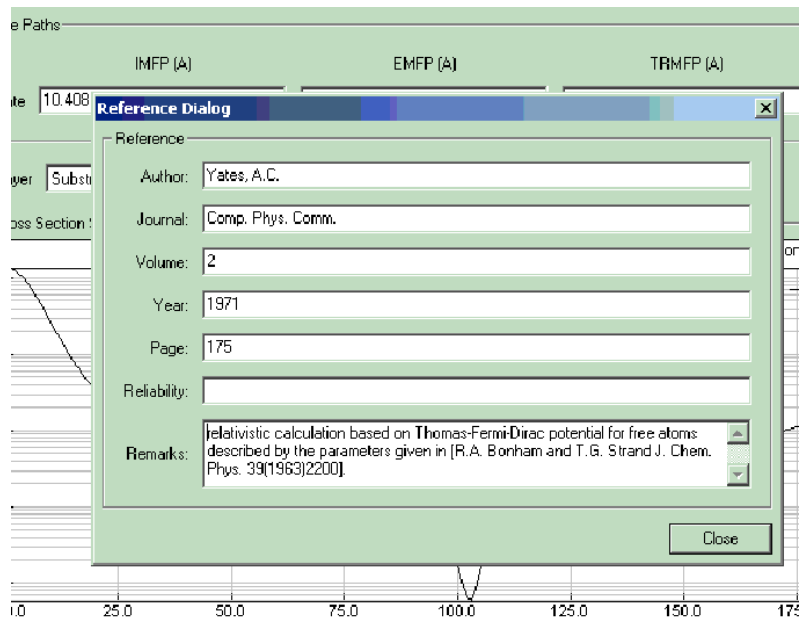
Figure 3.3. The reference dialog window.

Most quantities in SESSA that are represented by a single value can be changed by the user if desired. The database selection menu provides a quick way to retrieve any value from a database. Quantities that can only

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be represented by an array of values, such as the differential cross section, cannot generally be directly changed by the user.

The reference dialog is part of an implementation feature that provides full traceability of the data retrieved by SESSA: Every datum is accompanied by a reference that can be inspected at any time. In the GUI this is achieved by a right mouse click either on the numerical value of a parameter or on its graphical display window, as shown in Fig. 3.2. An example of the resulting information is given in Fig. 3.3. When fundamental physical data concerning an electron spectrum are given as outputs by the database (see Section 3.4), numbered references for all retrieved data are written to a separate file with the ending `"refs.txt"`, while the remarks in the lower two boxes of the reference dialog window are accordingly numbered and written to a file with the extension `"rems.txt"`.

3.2 The command line interface (CLI)

The CLI console can be opened by selecting the "Project/Command Line Interface" menu in the project menu or by pressing the shortcut key CTRL-9. The CLI console window is shown in Fig. 3.4. At the bottom of the CLI console, a number of buttons are seen. Clicking the "Command List" button opens a window within the CLI console that presents the structure of the commands of the CLI. Clicking on any of these commands generates a text string on the CLI corresponding to the command in question preceded by `HELP`. As a result, the help text corresponding to the selected command is displayed in the CLI. In Fig. 3.4 the above is illustrated for the command `SAMPLE PARAMETERS SET IMFP`. Any command appearing in the CLI may be edited by using the up and down arrow and the delete key etc., and can be entered by pressing return. In this way, a command generated by clicking on the command list can be used to operate the software. Thus the command list provides a most useful reference guide for the CLI syntax.

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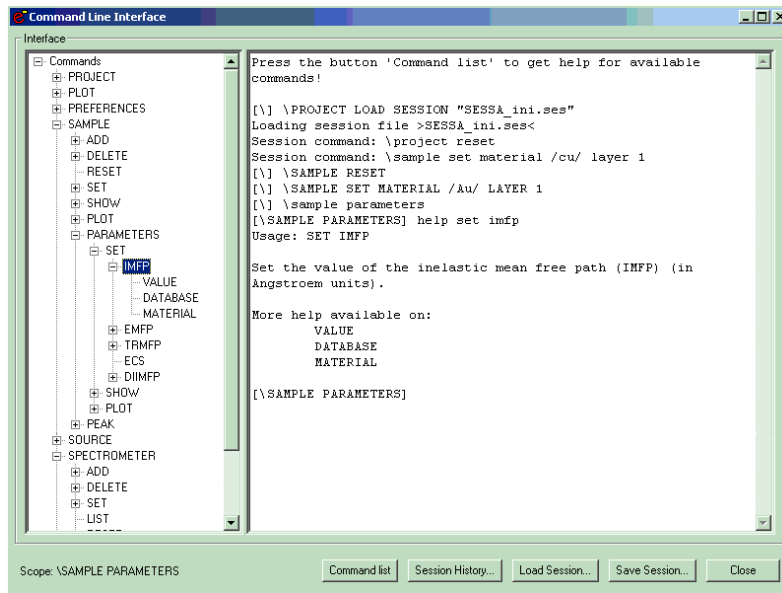
Figure 3.4. The command line interface console.

In the command line interpreter, the modularity of the software is realized by the use of different scopes, each scope allowing a user to manipulate or inspect a certain subset of the relevant data and control parameters corresponding to a window in the GUI. Table 3.2 gives a survey of the scopes presently defined in SESSA.[1] The acronyms shown in Table 3.2 are used frequently in SESSA, and are defined in Table 3.3.

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[1] In the present implementation of SESSA, there is an exception to the one-to-one correspondence between the GUI menus and the CLI scopes: the geometry, source, and spectrometer scopes have been organized as submenus of an experiment menu in the GUI but are separate scopes in the CLI. The scopes in the CLI will be modified later to match the menus in the GUI.

Table 3.2. Scopes and sub-scopes of the CLI. The acronyms are defined in Table 3.3. Further information is given in Section 6.1.

1	main	
2	\ sample	
3	\	\ peak
4	\	\ parameters
5	\ source	
6	\ spectrometer	
7	\ geometry	
8	\ simulation	
9	\ database	
10	\	\ DIIMFP
12	\	\ IMFP
13	\	\ ECS
14	\	\ EMFP
15	\	\ TRMFP
16	\	\ PCS
17	\	\ PAP
18	\	\ EIICS
19	\	\ XPL
20	\	\ AEL
21	\	\ FY
22	\	\ ABF

Table 3.3. Acronyms for the physical quantities in the SESSA databases.

IMFP   Inelastic Mean Free Path
DIIMFP   Differential Inverse Inelastic Mean Free Path
TECS   Total Elastic Cross Section
TRECS   Transport (Elastic) Cross Section
ECS   (Differential) Elastic Cross Section
EMFP   Elastic mean free path
TRMFP   Transport mean free path
PAP   Photoionization Asymmetry Parameter
EIICS   Electron Impact Ionization Cross Section
ABF   Auger Backscattering Factor
FY   Fluorescence Yield
PCS   Photoionization Cross Section
XPL   X-ray Photoelectron Lineshape
AEL   Auger Electron transition Lineshape

The active scope is indicated by the command prompt and at the bottom left of the CLI console window. To set a scope from within the main scope, one simply has to enter the name of the scope, as provided by Table 3.2. Any command entered in the CLI that is preceded by a backslash (\) is interpreted as if it were entered in the main scope. In

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particular, to set the scope from within another scope, one can enter the name of the scope preceded by a backslash (\). The `exit` command allows a user to move down one level in the hierarchy of scopes. The following example illustrates three alternative ways to set the scope to "Sample\Parameters":

1. directly from the main scope:
   ```
   [\]sample parameters
   [\ SAMPLE PARAMETERS]
   ```

2. in two steps from the main scope:
   ```
   [\]sample
   [\ SAMPLE] parameters
   [\ SAMPLE PARAMETERS]
   ```

3. directly from within any other scope:
   ```
   [\ DATABASE]\ sample parameters
   [\ SAMPLE PARAMETERS]
   ```

As an instructive example of the parallel operation of the GUI and CLI, press CTRL-5 to open the "Experiment/geometry" menu and change, say, the sample orientation azimuth (phi) to 45 degrees. Now press CTRL-9 to open the CLI console. On the console, the command `\GEOMETRY SET SAMPLE PHI 45 GEO 1` appears as it was generated by the GUI. By pressing the up, left and right arrows on the CLI console, the command can be edited and entered again, for example to set the sample azimuth to 30 degrees. Bringing the "Experiment/geometry" menu to the front again by pressing CTRL-5 gives a graphical display of the new orientation of the sample surface normal.

Scrolling through the list of commands processed by SESSA is possible by using the up and down arrow in the CLI console. Alternatively, a list of the processed CLI commands for review can be easily displayed by clicking on the "Session History" button in the CLI console. Any of the commands in this list can be processed again by double clicking on it. The session history can be cleared by pressing the corresponding button in the session history command list. This is an important feature for producing CLI command files using the "Save session" command (see below).

The great advantage of this parallel CLI/GUI interface is that a set of CLI commands can be read from or written to a text file, using the PROJECT LOAD/SAVE SESSION command or by pressing the "Load/save session" button on the CLI console. This makes it possible to process a large batch of commands. Such CLI command files can be produced in a simple way by a user without any knowledge of the CLI syntax. This can be done by a series of mouse clicks in the GUI and saving all previously entered

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commands by pressing the "Save session" button on the CLI console. The tutorials described in Section 7 are examples of CLI command files produced in this way. A # character at the beginning of a line in a CLI command file designates the line as a comment.

Another example of a SESSA CLI file is a file by the name of "SESSA_ini.ses" that resides in the directory where the SESSA binary code is located. This file is read whenever the software starts up and the commands contained in it are processed by the CLI. This may be advantageous for a user who commonly works on problems requiring settings that differ from the default settings in SESSA. This may concern the radiation type, the instrument settings, the sample composition, and so on.

3.3 Representation of Data in SESSA

A CLI command as well as an input field in the GUI may comprise special data types as indicated in Table 3.4. These data types are now described in turn.

1. **integer:** an integer number whose range depends on the operating system (OS) of the computer.

2. **real:** a real number with a range that also depends on the OS. The character e signifies exponentiation to a power of ten. For example, the expressions 0.0099, 99.0e-4 and 99e-4 are all valid expressions for the same real number.

3. **string:** a string of characters. A string may contain all alphanumerical characters and special characters (%, *, etc.) in upper or lower case. If a string contains spaces, it must be enclosed in single quotes, e.g., 'Au, 1000 eV'.

Table 3.4: Special data types for SESSA user interaction.

1	<integer>	an integer number
2	<real>	a real number
3	<string>	a string of characters
4	<filename>	a string designating a file of the OS
5	<Dbname>	a string designating a set of data within SESSA
6	<material>	a material specifier
7	<subshell>	a subshell specifier

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4. **filename:** a string of characters designating a file of the operating system with a filename valid in the operating system.

5. **DBName:** a predefined string of characters designating a set of data within SESSA (see Table 3.3 and Section 4.8).

6. **material:** The material specifier is a special string of characters that allows the program to recognize the elements and stoichiometry in a given material. It identifies the elements present in the sample and their chemical state, allowing the software to retrieve the relevant information.

The material specifier consists either of a number of compound specifiers, or a number of constituent specifiers, or both. The constituent specifier, enclosed in forward slashes (/) consists of an element identifier (the usual abbreviation of the elemental name from the periodic table of the elements), a chemical state attribute (an arbitrary string specified by the user enclosed in square brackets ([ ]), and a real number describing the abundance of this species in a given layer of the compound or material:

<constituent specifier> = /<element identifier>[<chemical state attribute>]<abundance>/

Here

<element identifier> represents a chemical symbol (e.g., H, He, Li, Be, ...) (case insensitive)

<chemical state attribute> is an arbitrary string indicating the chemical state

<abundance> is a positive real number indicating the relative abundance of the element in a given layer.

If the chemical state attribute is omitted, the software recognizes the constituent as the elemental form of the chemical species. If the relative abundance is omitted, it is taken to be unity.

A compound specifier consists of a number of constituent specifiers enclosed in parentheses '( )' followed by the relative abundance of the considered compound, or by several compound specifiers. Nesting of compound specifiers is allowed. Again, if the abundance is omitted, it is taken to be unity.

<compound specifier> = (A)x_A(B)x_B …

where A, B, … are arbitrary combinations of compound or constituent specifiers and x_A, x_B are their relative atomic abundances. The concentration of compound A in this material is given by:

$$c_A = \frac{x_A}{x_A + x_B + \ldots} \cdot$$

(3.1)

If the compound A is given by the constituents A_1, A_2, ... etc. with abundances x_{A1}, x_{A2}, ... etc., then A is specified as follows:

$$A = / A_1 x_{A1} / A_2 x_{A2} / \ldots /$$

(3.2)

and the concentration of the species A_i in the considered material is given by:

$$c_{Ai} = \left(\frac{x_{Ai}}{\sum_j xA_j} \right) \Big/ (x_A + x_B + \ldots) \, .$$

(3.3)

Some examples:

(a) /S/I/O3.0e0/. A (very hypothetical) solid consisting of the three elements sulfur, iodine and oxygen, all of them present in elemental form in relative amounts of 1:1:3.

(b) (/si[oxide]/O2/)99(/c/)1. A typical silicon dioxide layer that contains silicon bound to oxygen, oxygen and a carbon contamination. The relative amounts of the elements in the layer are 0.33:0.66:0.01.

7. **subshell:** a subshell may be specified by a string consisting of the principal quantum number n followed by the usual symbol for the angular momentum quantum number l (s for $l = 0$, p for $l = 1$, d for $l = 2$, and f for $l = 3$) and the usual symbol indicating the spin state (e.g., 1/2, 3/2, etc.). The subshell may be abbreviated to the unambiguous shortest form (e.g., 4f7 is equivalent to 4f7/2).

3.4 Output produced by SESSA

Information concerning the experimental settings specified by the user, the retrieved data corresponding to these settings, and the outcome of a model calculation can be written to a number of files by selecting the "Project/Save/Output" option in the GUI or by issuing the command `PROJECT SAVE OUTPUT` in the CLI. As a result, a number of different

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files containing information in several categories are generated. For several categories, writing of the output can be (de)activated in the "Project/preferences" menu (see Section 4.3).

1. filenames ending with: sam_lay.txt
   The sample structure

2. filenames ending with sam_peak.txt, sam_par.txt
   Signal-electron generation and transport

3. filenames ending with exp.txt, prefs.txt
   The experimental settings and preferences settings

4. filenames ending with refs.txt, rems.txt
   References to works in the literature concerning the above and accompanying remarks

5. filenames ending with .spc, .pi, .adf
   These files are written if a model calculation was performed and they contain the corresponding results. The output is divided into region data, corresponding to a certain energy-region setting for the spectrometer, and peak data, corresponding to a certain spectral line. The region data are written to files with names identified by the string `"reg<region number>"`, where `"<region number>"` is an integer referring to the spectrometer region. The peak data are written to files identified by a peak identifier, consisting of the chemical symbol followed by the transition specifier. This is either the subshell abbreviation in case of an XPS peak (e.g., 2p3) or the Auger transition specifier (e.g., L3M23M45). The file names ending with .spc contain the energy spectra of the various peaks and regions for all selected geometries. The file names ending with .pi contain the partial intensities for each peak and all geometries. If the number of geometries is larger than one, files ending with .adf are created that contain the partial intensities for the specified peak for all specified geometrical configurations. If `ncol=0` is selected in the model menu (see Section 4.9) and the number of specified geometries is larger than one, it is assumed that the angular distribution of the peak intensities (zero-order partial intensities) is of main interest. In this case, the file `all.adf` is created that contain the peak intensities for all peaks as a function of the specified geometrical configurations.

6. filenames ending with _g
   Files that can be loaded into the program GNUPLOT (see http://www.gnuplot.info) that has proven to be convenient for further graphical post-processing of the simulation data.

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An alternative quick and convenient means to produce output is to use the `PLOT SHOW DATA` option in the main plot window popup menu that displays the data contained in a plot in a separate read-only window (see Chapter 4.2), together with the relevant literature citation. The information in this window can be copied and pasted into another application for further processing.

4 RUNNING SESSA

This chapter describes all commands utilized by the command line interface (CLI) in some detail. Since a close correspondence exists between the CLI and the graphical user interface (GUI), no detailed description of the latter is given. In most cases, it is evident which component of the GUI provides the equivalence to a certain CLI command. In the CLI, however, it is often necessary within a command to specify which peak, which geometry, which layer, etc., one is addressing with the issued command. This situation can lead to awkward syntax such as `DO SOMETHING LAYER 1 PEAK 2 REGION 3`. In the GUI, the situation can be handled in a more elegant way within a submenu by means of one or more graphical selection tools. For example, there is an equivalence between the "Choose peak" and "Choose layer" selection boxes in the "Sample/parameters" menu in the GUI and the peak number and layer number in the equivalent CLI command (`SAMPLE PARAMETERS PLOT ECS PEAK <PEAK #> LAYER <LAYER #>`).

In the following sections concerning the CLI syntax of various scopes, < > represents a parameter of the type indicated that has to be entered by the user, while [ ] is an optional parameter that may be omitted.

The energies displayed in and accepted by both the GUI and the CLI can be specified either on a kinetic energy scale or, in the case of incoming photons, it may optionally be specified on a binding energy scale. The user can set a preference in the "Project/preferences" menu. Depending on this setting, an energy referred to in the remainder of this Section is implied to be specified either on a kinetic or a binding-energy scale.

4.1 The PROJECT Menu

The Project menu in the GUI is shown in Fig. 4.1. The CLI console, the separate plot window, and the preferences dialog can be opened from within the project menu. The plot window, the CLI console, and the preferences dialog are described below. The project menu is otherwise equivalent to the project menu in the CLI, as described in the next Section.

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Figure 4.1. Graphical user interface for the PROJECT Menu.

4.1.1 Synopsis of CLI Commands

1. PROJECT SAVE SESSION <string>
    Save command history to the file <string >. Each command typed in during your session (or generated by clicking in the GUI) is written to a text file. This file may be later executed, but it can also be edited and modified to enable processing of a batch of commands. In this way, one can generate calibration curves of various kinds, angular distributions of peak intensities, etc.

2. PROJECT SAVE OUTPUT <string>
    Save output to files beginning with the ID <string >.

3. PROJECT LOAD SESSION <string>
    Load command history from the file <string >.

4. PROJECT RESET
    Clear all data and reset everything to the default values.

4.2 The PLOT Menu

Data can be displayed in a separate window that allows full user access to the display parameters by double clicking the window. Various quantities in SESSA can be graphically displayed. These displays cannot in any way be changed by the user. However, by double clicking on any of these windows, a separate plot window is opened providing full user access to the plot settings, as shown in Fig. 4.2 as an example. This plot window is also accessible via the "Project/Plotwindow" command in the GUI and through appropriate commands (pertaining to the quantity on display) in the CLI. A right mouse click in the plot window activates a popup menu that opens the plot settings window (see Fig. 4.2), a comprehensive menu for manipulating the settings of the display.

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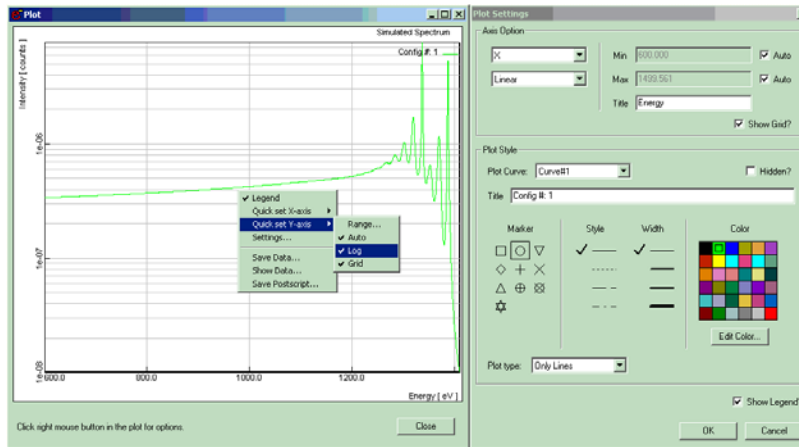
Fig. 4.2. Graphical user interface for the PLOT and the PLOT/Settings Menu.

Alternatively, the quick axis settings menu can be activated. The latter allows a user to set the axis range, and to turn on/off an axis grid or a logarithmic scaling of the axis. Furthermore, the popup menu can be utilized to open a read-only window displaying the data contained in the plot along with the corresponding references, as indicated in Fig. 4.3.

4.2.1 Synopsis of CLI Commands

1. PLOT SET LOG X
   Selects the x-axis for logarithmic scaling.

2. PLOT SET LOG Y
   Selects the y-axis for logarithmic scaling.

3. PLOT SET NOLOG X
   Selects the x-axis for linear scaling.

4. PLOT SET NOLOG Y
   Selects the y-axis for linear scaling.

5. PLOT SET AUTO XRANGE
   Selects the upper and lower limits of the x-axis for automatic scaling.

6. PLOT SET AUTO XLOW
   Selects the lower limit of the x-axis for automatic scaling.

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```
Show data                                                        ☒

; format  : curve #1.x (tab) curve #1.y (tab) curve #2.x (tab)
curve #2.y (tab) ...
; title   : Simulated Spectrum
; abscissa: Energy [eV]
; ordinate: Intensity [counts]
;================================================================
=======================================
; Curve #1 (x,y): Config #: 1
; Reference: W.S.M. Werner, W. Smekal and C. J. Powell, Simulation
of Electron Spectra for Surface Analysis (SESSA-V1.0) National
Institute of Standards and Technology, Gaithersburg, MD (2004),
; Reliability:
; Remarks:
;================================================================
=======================================
; Curve #2 (x,y): Config #: 2
; Reference: W.S.M. Werner, W. Smekal and C. J. Powell, Simulation
of Electron Spectra for Surface Analysis (SESSA-V1.0) National
Institute of Standards and Technology, Gaithersburg, MD (2004),
; Reliability:
; Remarks:
;================================================================
=======================================
600.000000 0.000000    600.000000 0.000000
600.439453 0.000000    600.439453 0.000000
600.878906 0.000000    600.878906 0.000000
601.318359 0.000000    601.318359 0.000000
601.757813 0.000000    601.757813 0.000000
602.197266 0.000000    602.197266 0.000000
602.636719 0.000000    602.636719 0.000000
603.076172 0.000000    603.076172 0.000000
603.515625 0.000000    603.515625 0.000000
603.955078 0.000000    603.955078 0.000000
604.394531 0.000000    604.394531 0.000000
604.833984 0.000000    604.833984 0.000000
605.273438 0.000000    605.273438 0.000000
605.712891 0.000000    605.712891 0.000000
606.152344 0.000000    606.152344 0.000000

                                                    [  OK  ]
```

Figure 4.3. Read-only window displaying the data contained in the Plot
window. The data in this window can be transferred to other software by
means of copy and paste operations for further processing.

7. PLOT SET AUTO XHIGH
    Selects the upper limit of the x-axis for automatic scaling.

8. PLOT SET AUTO YRANGE
    Selects the upper and lower limits of the y-axis for automatic scaling.

9. PLOT SET AUTO YLOW
    Selects the lower limit of the y-axis for automatic scaling.

10. PLOT SET AUTO YHIGH
    Selects the upper limit of the y-axis for automatic scaling.

11. PLOT SET GRID X
    Selects the x-axis grid for drawing.

12. PLOT SET GRID Y
    Selects the y-axis grid for drawing.

13. PLOT SET NOGRID X
    Disable drawing of the grid for the x-axis.

14. PLOT SET NOGRID Y
    Disable drawing of the grid for the y-axis.

15. PLOT SET LEGEND
    Activate drawing of a legend in the plot.

16. PLOT SET NOLEGEND
    Deactivate drawing of a legend in the plot.

17. PLOT SET XRANGE <string>
    Sets the x-axis range to <string >. Syntax to specify the range:
    xlow:xhigh. Example: set xrange 1400:1500.

18. PLOT SET YRANGE <string>
    Sets the y-axis range to <string >. Syntax to specify the range:
    ylow:yhigh. Example: set yrange 1400:1500.

19. PLOT SET CURVETITLE <string> [CURVE <int>]
    Sets the legend of the curve to <string >, where CURVE is the
    number of the selected curve.

20. PLOT SET LTYPE <int> [CURVE <int>]
    Sets the linetype of the selected curve (0- data points; 1- solid line; 2-
    data points and line), where CURVE is the number of the selected
    curve.

21. PLOT SET COLOR <int> [CURVE <int>]
    Sets the color of the selected curve (integer between 0 and 35),
    where CURVE is the number of the selected curve.

22. PLOT SET WIDTH <int> [CURVE <int>]
    Sets the linewidth of the selected curve (integer between 0 and 3),
    where CURVE is the number of the selected curve.

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23. PLOT SET DASH <int> [CURVE <int>]
    Sets the dash style of the selected curve (integer between 0 and 3),
    CURVE is the number of the selected curve.

24. PLOT SET SYMBOL <int> [CURVE <int>]
    Sets the symbol style of the selected curve (integer between 1 and
    10), where CURVE is the number of the selected curve.

25. PLOT SET VISIBLE CURVE <int>
    Number of the selected curve.

26. PLOT SET VISIBLE ALL
    Sets all curves to visible.

27. PLOT SET INVISIBLE CURVE <int>
    Number of the selected curve.

28. PLOT SET INVISIBLE ALL
    Selects all curves for hiding.

29. PLOT SET TITLE <string>
    Sets the title of the plot to <string >.

30. PLOT SET XLABEL <string>
    Sets the x-axis label of the plot to <string >.

31. PLOT SET YLABEL <string>
    Sets the y-axis label of the plot to <string >.

32. PLOT SAVE DATA <string>
    Save plot data of each curve to the text file <string >.

4.3 The PREFERENCES Menu

The preferences menu allows a user to control various parameters
determining the operation of SESSA as is shown in Fig. 4.4.

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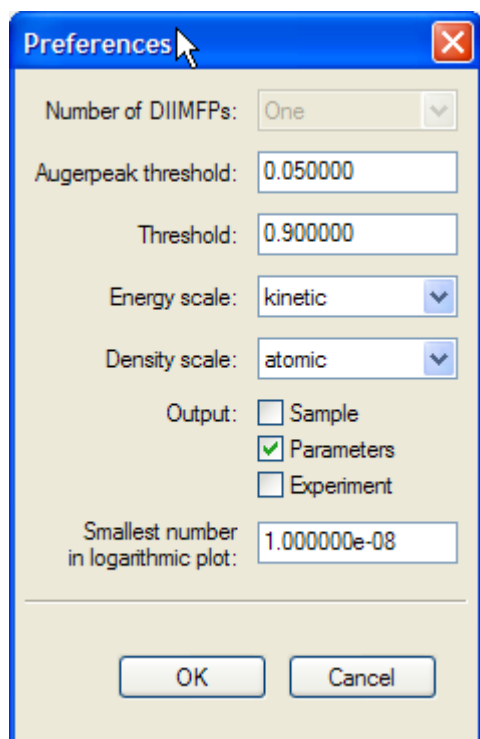
Figure 4.4. Graphical user interface for the PREFERENCES Menu.

4.3.1 Synopsis of CLI Commands

1. PREFERENCES SET NDIIMFP <int>
    Set the number of different distributions of energy losses for the
    upper two layers in the sample. When the default value is chosen
    (NDIIMFP=1), it is assumed in a simulation that the differential
    inelastic mean free path is the same for all depths. This assumption
    usually provides a satisfactory approximation. However, if the
    electronic structures of the first two layers of the sample are
    substantially different, this difference may be observed in the loss
    features on the low-kinetic-energy side of the main peaks. In such
    cases it may be advisable to choose (NDIIMFP=2). Note that this
    may considerably increase the computation time for a simulation.
    Choosing yet another distribution of energy losses for deeper layers
    is not possible, but such effects will hardly ever be observable in an
    experimental spectrum.

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2. PREFERENCES SET THRESHOLD <double> (for Threshold)
   Sets a threshold determining whether a peak retrieved from a database should actually be taken into account in any of the energy regions, as defined in the spectrometer menu. If the fractional area of a peak within the region is below this threshold, the peak is rejected from the peak list. The default value is 0.9.

3. PREFERENCES SET AES_THRESHOLD <double> (for Augerpeak threshold)
   Sets a threshold determining whether an Auger peak retrieved from a database should actually be taken into account in any of the energy regions, as defined in the spectrometer menu. If the intensity of an Auger peak (estimated from the multiplicities of the subshells involved in the Auger transition) is less than this threshold times the maximum intensity for other Auger peaks from the same element within the same energy region, the peak is rejected from the peak list. The default value is 0.05.

4. PREFERENCES SET PLOT_ZERO <double>
   Sets the smallest positive number displayable in a logarithmic plot.

5. PREFERENCES SET ENERGY_SCALE KINETIC
   Sets the energy scale to kinetic energy.

6. PREFERENCES SET ENERGY_SCALE BINDING
   Sets the energy scale to binding energy if the excitation is with photons.

7. PREFERENCES SET OUTPUT SAMPLE <string>
   If <string> = true, information concerning the sample composition is included in the output.

8. PREFERENCES SET OUTPUT PARAMETERS <string>
   If <string> = true, information concerning the parameters for electron generation and transport is included in the output.

9. PREFERENCES SET OUTPUT EXPERIMENT <string>
   If <string> = true, information concerning the experimental settings is included in the output.

10. PREFERENCES SHOW
    Show the values of the parameters in the PREFERENCES menu (only available in the CLI).

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4.4 The SAMPLE Menu

This menu controls the parameters specifying the structure of the sample and the physical parameters of the sample of relevance for the particular experimental conditions, as indicated in Fig. 4.5. The sample is conceived to consist of a number of non-crystalline and continuous layers each with a given composition, density and thickness. The interface between the various layers is assumed to be ideally flat, except for the vacuum-solid interface that may exhibit a certain morphology. Presently, one morphology type besides an ideally flat surface is implemented: a surface with a given roughness, specified by the relative surface area (RSA) as defined below [5]. The material in a given layer is specified by a special string describing the elemental composition (see below). All relevant parameters for a specified material are retrieved by the expert system and can be inspected and changed in the "Sample peak" menu (see Section 4.4.5) and the "Sample parameter" menu (see Section 4.4.3). A value for the density of each layer is also determined for each layer. For elemental solids, this quantity is read from a database; for most other materials, it is estimated on the basis of elemental densities of the constituents in each
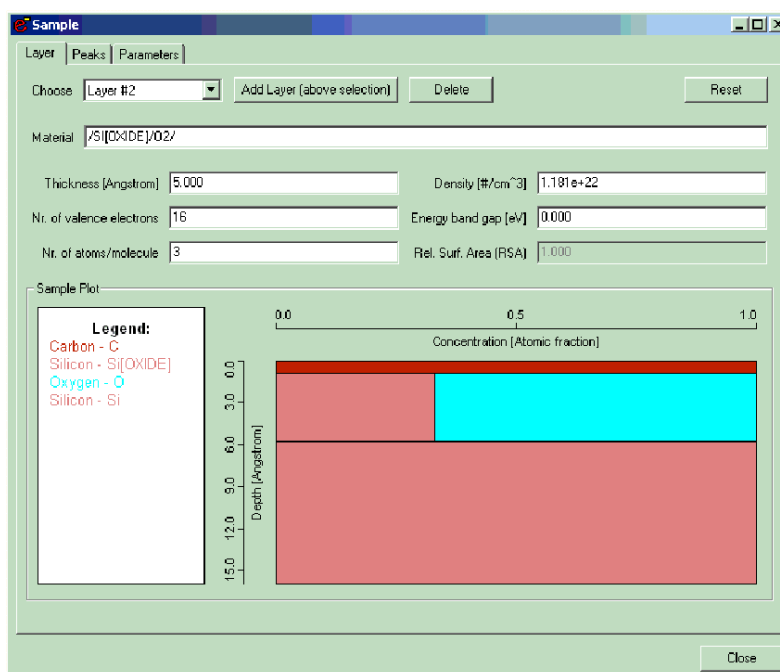

Figure 4.5. Graphical user interface for the SAMPLE Menu.

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layer. The estimated density may be in error by more than 100 %. It is therefore recommended that the user should specify a more realistic value for the density in such cases.

4.4.1 The SAMPLE LAYER Menu

This menu (selected by the Layer tab in the Sample menu of Fig. 4.5) controls the parameters specifying the thickness, density, bandgap energy, number of valence electrons per atom or molecule, number of atoms per molecule, composition, thickness, and roughness of the surface.

4.4.2 Synopsis of CLI Commands

1. SAMPLE ADD LAYER <string> THICKNESS <double> [ABOVE <int>]
    Adds a new layer above the selected layer. The material of the layer is specified by the material identifier <string > (see Section 3.3).
    - THICKNESS: Specify the thickness (in Å) of the layer to be added.
    - ABOVE: Add the layer above the specified layer instead of above the layer that is selected in the "Choose layer" box.

2. SAMPLE DELETE LAYER <int>
    Delete the specified layer.

3. SAMPLE RESET
    Reset the complete sample structure to its default (a homogeneous Si sample).

4. SAMPLE SET ACTLAY <int>
    Set the number of a given layer to which all following commands apply per default.

5. SAMPLE SET DENSITY <double> [LAYER <int>]
    Set the density of a given layer (in atoms/cm^3), where LAYER is the number of the selected layer.

6. SAMPLE SET EGAP <double> [LAYER <int>]
    Set the band-gap energy (in eV) of a material in a given layer, where LAYER is the number of the selected layer.

7. SAMPLE SET NVALENCE <int> [LAYER <int]
    Set the number of valence electrons per atom or molecule of a material in a given layer, where LAYER is the number of the selected layer.

8. SAMPLE SET NATOMS <int> [LAYER <int>]

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Set the number of atoms per molecule of a material in a given layer, where LAYER is the number of the selected layer.

9. SAMPLE SET MATERIAL <string> [LAYER <int>]
    Set the material of a given layer by providing a material specifier <string > (see Section 3.3), where LAYER is the number of the selected layer.

10. SAMPLE SET THICKNESS <double> [LAYER <int>]
    Set the thickness (in Å) of a given layer, where LAYER is the number of the selected layer.

11. SAMPLE SET RSA <double>
    Set the roughness of the sample surface. A rough surface is assumed to consist of tilted surface segments with a certain distribution of tilt angles. The roughness is specified by the relative surface area (RSA)[5], that is the mean value of the reciprocal of the cosine of the tilt angles. In other words, the relative surface area is the area of the surface when measured along the tilted surface segments, divided by the area of the surface segments projected onto the global surface. Consequently, RSA=1 represents an ideally smooth surface. Realistically rough surfaces are described by an RSA value between 1.05 and 1.2.

12. SAMPLE SHOW SAMPLE
    Show the parameters describing the sample structure in the CLI.

13. SAMPLE SHOW LAYER <int>
    Show the parameters describing a single layer in the sample in the CLI.

14. SAMPLE PLOT SAMPLE
    Graphical display of the concentration-depth profile of the sample.

4.4.3 The SAMPLE PARAMETERS Menu

This menu (selected by the Parameters tab in the Sample menu of Fig. 4.5) controls the parameters for the electron/solid interaction as shown in Fig. 4.6.

4.4.4 Synopsis of CLI Commands

1. SAMPLE PARAMETERS SET IMFP VALUE <double> PEAK <int> LAYER <int>
    Set the value of the inelastic mean free path (IMFP) for a given peak in a given layer (in Å).

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- PEAK: Number of the selected peak.
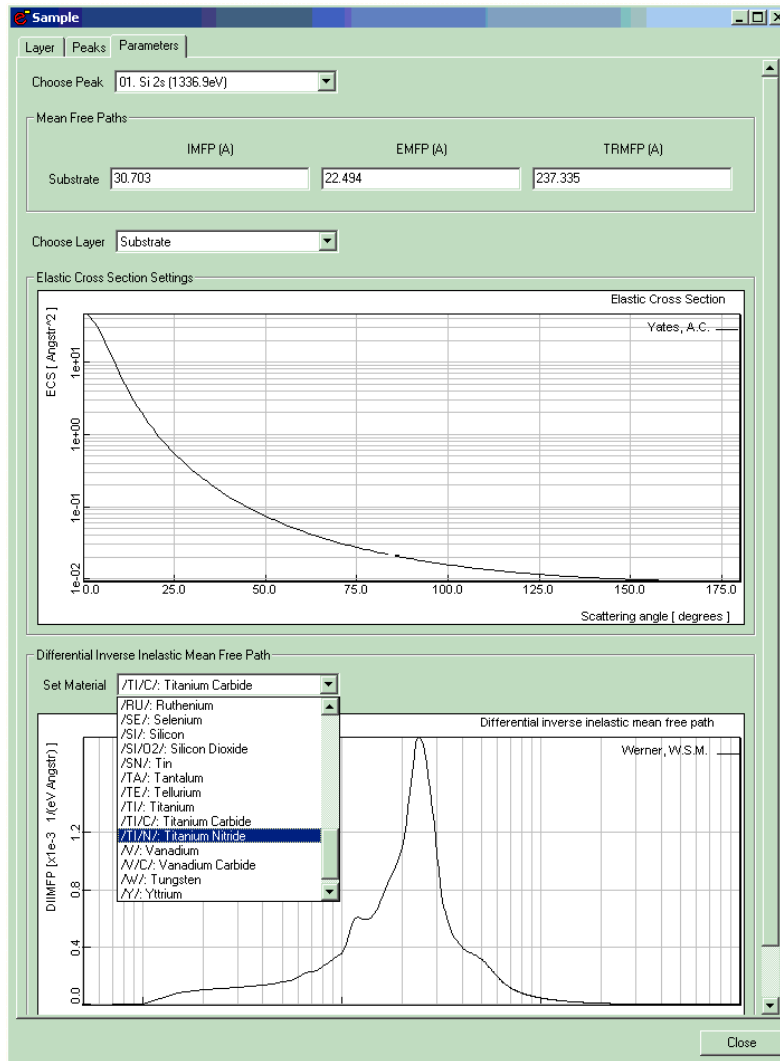- LAYER: Number of the selected layer.

Figure 4.6. Graphical user interface for the SAMPLE PARAMETERS Menu.

2. SAMPLE PARAMETERS SET IMFP DATABASE <string> LAYER <int>
    Select a database for retrieval of IMFP values, where LAYER is the number of the selected layer.

3. SAMPLE PARAMETERS SET IMFP MATERIAL <string> LAYER <int>
    Option to search the database of IMFP values derived from optical data. In this case, the material identifier should be a string as described in Section 3.3 (e.g., Si, Sio2, TiC, etc.). Note that optical data are only available for a limited number of materials. If the requested material is not found, the default database for the IMFP is automatically invoked. This default returns an estimate for the IMFP derived from the TPP-2M formula [6] (see also "help database imfp show" for a list of available databases for this quantity). LAYER is the number of the selected layer.

4. SAMPLE PARAMETERS SET EMFP VALUE <double> PEAK<int>LAYER <int>
    Set the value of the elastic mean free path (EMFP) (in Å) for a given peak in a given layer.
    • PEAK: Number of the selected peak.
    • LAYER: Number of the selected layer.

5. SAMPLE PARAMETERS SET EMFP DATABASE <string> LAYER <int>
    Select a database to retrieve the value of the EMFP (see also "help database emfp show" for a list of available databases for this quantity), where LAYER is the number of the selected layer.

6. SAMPLE PARAMETERS SET TRMFP VALUE <double> PEAK <int> LAYER <int>
    Set the value of the transport mean free path (TRMFP) (in Å) for a given peak in a given layer.
    • PEAK: Number of the selected layer.
    • LAYER: Number of the selected layer.

7. SAMPLE PARAMETERS SET TRMFP DATABASE <string> LAYER <int>
    Select a database to retrieve the value of the TRMFP (see also "help database trmfp show" for a list of available databases for this quantity), where LAYER is the number of the selected layer.

8. SAMPLE PARAMETERS SET ECS DBNAME <string>PEAK <int> [LAYER<int>]

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Select a database to retrieve the value of the elastic cross section (ECS) (see also "help database ecs show" for a list of available databases for this quantity).
- DB NAME: Name of the database.
- PEAK: Number of the selected peak.
- LAYER: Number of the selected layer.

9. SAMPLE PARAMETERS SET DIIMFP DATABASE <string> LAYER <int>
   Select a database to retrieve the value of the differential inverse inelastic mean free path (DIIMFP) (see also "help database diimfp show" for a list of available databases for this quantity), where LAYER is the number of the selected layer.

10. SAMPLE PARAMETERS SET DIIMFP MATERIAL <string> LAYER <int>
    Option requesting the program to search the database of optical data for evaluation of the DIIMFP. In this case the material identifier should be an ordinary (non-case sensitive) string (e.g., Si, Sio2, TiC, etc.). Note that optical data are only available for a limited number of materials. If the requested material is not found, the default database for the DIIMFP is automatically invoked. This default returns Tougaard's universal DIIMFP [7]. LAYER is the number of the selected layer.

11. SAMPLE PARAMETERS SHOW PEAK <int>
    Show information about the electron-solid interaction for the selected peak in the CLI.

12. SAMPLE PARAMETERS PLOT ECS PEAK <int> [LAYER <int>]
    Display the elastic cross section for given peak and layer. Note that for a layer containing a compound, the elastic cross section is a weighted average of the elemental cross sections for the elements comprising the compound.
    - PEAK: Number of the selected peak.
    - LAYER: Number of the selected layer.

13. SAMPLE PARAMETERS PLOT DIIMFP [LAYER <int>] [PEAK <int>]
    Display the differential inverse inelastic mean free path for a given layer.
    - LAYER: Number of the selected layer.
    - PEAK: Number of the selected peak.

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4.4.5 The SAMPLE PEAK Menu

This menu (selected by the Peaks tab in the Sample menu of Fig. 4.5) controls the attributes of the peaks in the sample that contribute to the specified energy regions, as shown in Fig. 4.7. The peaks of signal electrons that have a source energy distribution lying within the energy regions of the spectrometer, as specified by the user, can be inspected and modified in this menu. Note that depending on the source energy and material of interest, it may happen that no peaks occur in the specified regions. In such cases, various data sets in SESSA are void that would otherwise contain information on the signal-electron peaks and parameters associated with them. A peak for an element may contain a number of subpeaks that are described by a functional form, relative height and width, or are given by an empirical peak shape read from a data file. Presently, SESSA does not contain detailed information on
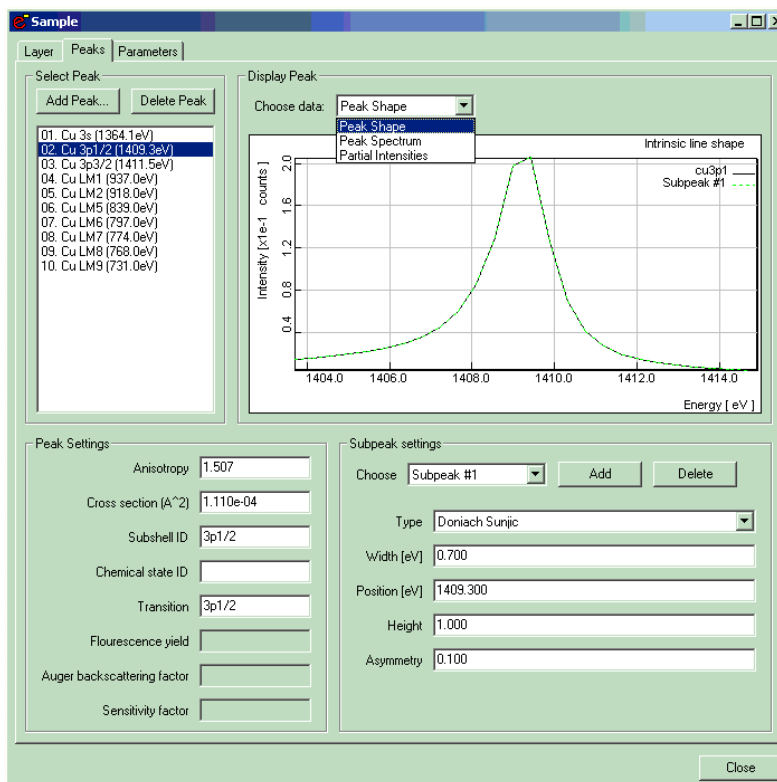

Figure 4.7. Graphical user interface for the SAMPLE PEAK Menu.

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intrinsic peak shapes: the intrinsic peak is assumed to be described sufficiently well in terms of a Gaussian, Lorentzian or Doniach-Sunjic peak shape. With each peak, there are associated a number of parameters such as the subshell identifier, cross section, fluorescence yield (only for Auger transitions), etc. The graphical display for the sample peak menu shows the intrinsic peak shape by default. By means of the "Choose data" box, a user can choose to change the display to the simulated spectrum or the simulated partial intensities. By double-clicking on the display, a new window opens with a display that can be modified by the user. A right mouse click in the new window gives options for showing and saving the displayed data.

4.4.6 Synopsis of CLI Commands

1. SAMPLE PEAK SET ACTPEAK <int>
   Set the peaks in the sample to which all of the following commands apply by default.

2. SAMPLE PEAK SET ABF VALUE <double> [PEAK <int>]
   Set the value of the Auger backscattering factor (ABF) for a given peak, where PEAK is the number of the selected peak.

3. SAMPLE PEAK SET ABF DATABASE <string> [PEAK <int>]
   Select a database to retrieve the value of the ABF (see also "help database ABF show" for a list of available databases for this quantity), where PEAK is the number of the selected peak.

4. SAMPLE PEAK SET FY VALUE <double> [PEAK <int]
   Set the value of the fluorescence yield (FY) for a given peak, where PEAK is the number of the selected peak.

5. SAMPLE PEAK SET FY DATABASE <string> [PEAK <int>]
   Select a database to retrieve the value of the FY (see also "help database FY show" for a list of available databases for this quantity), where PEAK is the number of the selected peak.

6. SAMPLE PEAK SET ANISOTROPY <double> [DBNAME <string>] PEAK <int>
   Set the asymmetry parameter (PAP) for the photoionization cross section of a given peak in XPS. Alternatively, this command can be used to set the database for retrieval of this quantity for a given peak. DBNAME: If the DBNAME option is specified, the photoionization asymmetry parameter is retrieved from the database indicated. In this case any value for the PAP specified in the command line will be ignored. See also "help database PAP show" for a list of available databases for this quantity). PEAK is the number of the selected peak.

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- DBNAME: Tells the software to retrieve the relevant cross section from the specified database (see also "help database EIICS show" for a list of available databases for this quantity).
- PEAK: Number of the selected peak.

7. SAMPLE PEAK SET CROSS_SECTION <double> [DBNAME <string>] PEAK <int>
Set the ionization cross section (in Å^2) associated with the peak for the specified incoming radiation. When electrons are used as exciting radiation, the cross section is the electron-impact ionization cross section (EIICS). When photons are used, the cross section is the photoionization cross section (PCS).
- DBNAME: Tells the software to retrieve the relevant cross section from the specified database (see also "help database EIICS show" for a list of available databases for this quantity).
- PEAK: Number of the selected peak.

8. SAMPLE PEAK SET TYPE <string> [PEAK <int>] SUBPEAK <int>
Set the subpeak type. The possible subpeak types are: GAUSS, LORENTZ, DONIACH_SUNJIC, EMPIRICAL (see Section 4.4.5). Any peak in the spectrum may be described by a linear combination of several subpeaks, each with a position, width, and relative intensity.
- PEAK: Number of the selected peak.
- SUBPEAK: Number of the selected subpeak.

9. SAMPLE PEAK SET WIDTH <double> [PEAK <int>] SUBPEAK <int>
Set the width of the subpeak (in eV) (ignored for peaks described by empirical data). The width of the value of the parameter describing the peak width for the selected subpeak type (e.g., the Gaussian width is the value of σ in the Gaussian expression).
- PEAK: Number of the selected peak.
- SUBPEAK: Number of the selected subpeak.

10. SAMPLE PEAK SET POSITION <double> [PEAK <int>] SUBPEAK <int>
Set the energy (in eV) of the subpeak position (ignored for peaks described by empirical data).
- PEAK: Number of the selected peak.
- SUBPEAK: Number of the selected subpeak.

11. SAMPLE PEAK SET HEIGHT <double> [PEAK <int>] SUBPEAK <int>
Set the relative height of the subpeak (in arbitrary units).
- PEAK: Number of the selected peak.

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- SUBPEAK: Number of the selected subpeak.

12. SAMPLE PEAK SET ASYMMETRY <double> [PEAK <int>]
    SUBPEAK <int>
    Set the asymmetry parameter for the Doniach-Sunjic formula
    (ignored for other peak types).
    - PEAK: Number of the selected peak.
    - SUBPEAK: Number of the selected subpeak.

13. SAMPLE PEAK SET CHEMSTATID <string> [PEAK <int>]
    Set the chemical state identifier of the peak. The chemical state
    identifier is an arbitrary string of characters that may be provided by a
    user to distinguish between the same atoms present in different
    states in the sample. It is not in any way interpreted by SESSA, but
    merely used to label peaks of the same element present in a different
    form (e.g., a different physical or, more commonly, chemical state) in
    the specimen. In a simulation, all peaks of an element corresponding
    to the same transition but with a different chemical state identifier are
    treated as separate peaks. PEAK is the number of the selected peak.

14. SAMPLE PEAK SET SENSFAC <double> [PEAK <int>]
    Set the sensitivity factor of the peak. This quantity is a correction
    factor for Auger peaks in cases for which the fluorescence yield and
    Coster-Kronig transition probability are not well known, where PEAK
    is the number of the selected peak.

15. SAMPLE PEAK ADD AESPEAK ENERGY <double> TRANSITION
    <string> SUBSHELLID <string> ELEMENT <string> [CHEMSTATID
    <string>]
    Add an Auger peak specified by the user to the list of peaks.
    - ENERGY: Energy (in eV) of the peak.
    - TRANSITION: The transition for the Auger peak.
    - SUBSHELLID: The subshell that is ionized initially and leads to the
      considered Auger transition.
    - ELEMENT: The element emitting the signal electrons.
    - CHEMSTATID: Chemical state label for a peak.

16. SAMPLE PEAK ADD XPSPEAK ENERGY <double> SUBSHELLID
    <string> ELEMENT <string> [CHEMSTATID <string>]
    Add a photoelectron peak specified by the user to the list of peaks.
    - ENERGY: Energy (in eV) of the peak.
    - SUBSHELLID: Subshell of the photoelectron peak.
    - ELEMENT: Element emitting the signal electrons.
    - CHEMSTATID: Chemical state for the peak.

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17. SAMPLE PEAK ADD SUBPEAK PEAK <int> ENERGY <double>
    Add a subpeak to the peak data structure.
    - PEAK: Number of the selected peak.
    - ENERGY: Specify the energy (in eV) for the subpeak.

18. SAMPLE PEAK DELETE PEAK <int> [SUBPEAK <int>]
    Delete an attribute of the peak data structure.
    - PEAK: Number of the selected peak.
    - SUBPEAK: Number of the selected subpeak.

19. SAMPLE PEAK SHOW [PEAK <int>] [SUBPEAK <int>]
    Show information on the data for the peak.
    - PEAK: Number of the selected peak.
    - SUBPEAK: Number of the selected subpeak.

20. SAMPLE PEAK LIST [PEAK <int>]
    Show peak position, width parameter, relative intensity, and peak
    type for all peaks or for a selected peak and any of its subpeaks.
    PEAK is the number of the selected peak.

21. SAMPLE PEAK PLOT SPEC [PEAK <int>]
    Graphical display of the partial spectrum emitted from the surface,
    where PEAK is the number of the selected peak.

22. SAMPLE PEAK PLOT PART_INT [PEAK <int>]
    Graphical display of the partial intensities of electrons emitted from
    the surface, where PEAK is the number of the selected peak.

23. SAMPLE PEAK PLOT SHAPE [PEAK <int>] [SUBPEAK <int]
    Graphical display of the partial spectrum emitted at the location in the
    sample where the signal-electron excitation takes place.
    - PEAK: Number of the selected peak.
    - SUBPEAK: Number of the selected subpeak.

24. SAMPLE PEAK OUTPUT SPEC FILE <string> [PEAK <int>]
    Writes the spectrum for the selected peak to a file.
    - FILE: Name of the output file.
    - PEAK: Number of the selected peak.

25. SAMPLE PEAK OUTPUT PART_INT FILE <string> [PEAK <int>]
    Writes the partial intensities for the selected peak to a file.
    - FILE: Name of the output filet.
    - PEAK: Number of the selected peak.

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26. SAMPLE PEAK LOAD DATA <string> [PEAK <int>] SUBPEAK <int>
Loads an ASCII file containing the peak shape of a given subpeak for an EXISTING peak. Before peak shape data can be loaded for a new peak, this peak has to be defined by adding it (see SAMPLE ADD PEAK). The expected format for each line of this file is: "energy (eV)/ one or more spaces/ intensity (arb. units)".
- PEAK: Number of the selected peak.
- SUBPEAK: Number of the selected subpeak.

4.5 The SOURCE Menu

This menu specifies the source of exciting radiation for an experiment, as shown in Fig. 4.8. If an attribute of the source is changed, the expert system must start a new query for many relevant quantities. This means that previous user input for any of these quantities will be lost in such cases. For example, definitions concerning the shape, position or relative intensities of a peak that was manually added by a user as well as the corresponding interaction parameters will be erased. To save such user settings, it is advisable to save the session (see the command PROJECT SAVE SESSION in Section 4.1.1).
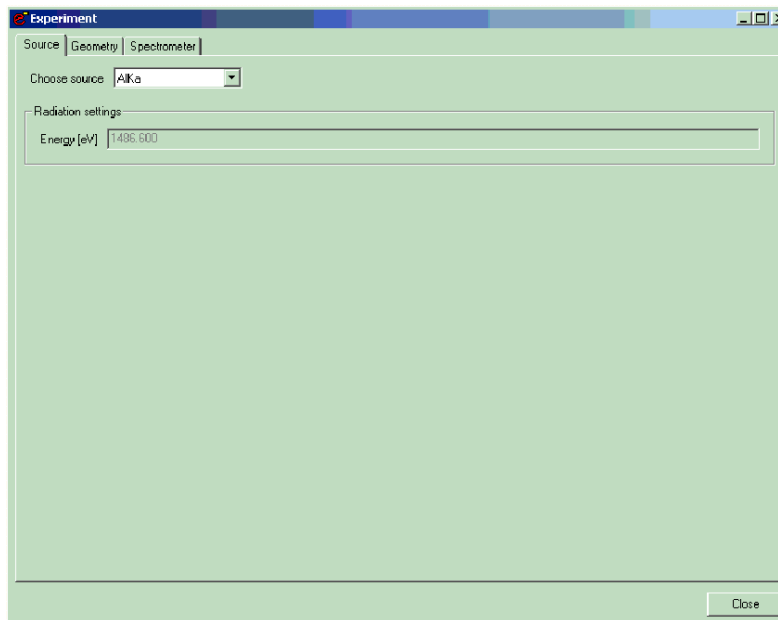

Figure 4.8. Graphical user interface for the SOURCE Menu.

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4.5.1 Synopsis of CLI Commands

1. SOURCE SET ALKA
    Sets the source to Al Kα radiation.

2. SOURCE SET MGKA
    Sets the source to Mg Kα radiation.

3. SOURCE SET ZRMZ
    Sets the source to Zr Mζ radiation.

4. SOURCE SET PHOTONS ENERGY <double>
    Sets the source to photons with an energy as specified, where
    ENERGY is the photon energy (in eV).

5. SOURCE SET ELECTRONS ENERGY <double>
    Sets the source to electrons with an energy as specified, where
    ENERGY is the electron energy (in eV).

6. SOURCE SHOW
    Shows the parameters of the SOURCE menu.

4.6 The SPECTROMETER Menu

This menu specifies the energy ranges of interest as well as the
parameters describing the spectrometer used to measure the spectrum in
this range, as shown in Fig. 4.9. A number of (non-overlapping) energy
regions may be specified. A spectrometer region may not be more
than 3000 eV wide. When retrieving the parameters needed to interpret
an electron spectrum, the expert system looks for peaks of the specified
sample that fall into one of the selected regions. At present, the simulated
spectrum corresponds to electrons emitted from the sample. All effects of
the instrumentation on an electron spectrum that may be observed in an
experiment (analyzer transmission function, energy dependence of the
energy resolution, etc.) are neglected in the present version of SESSA.

4.6.1 Synopsis of CLI Commands

1.   SPECTROMETER ADD REGION [RANGE <string>]
Add a new energy region for which a spectrum is to be simulated, where
RANGE defines the range of the spectrometer energy window in eV. For
example, SPECTROMETER ADD REGION RANGE 900:1400 will add a
region with an energy window of 900 eV to 1400 eV.

2.   SPECTROMETER DELETE REGION <int>
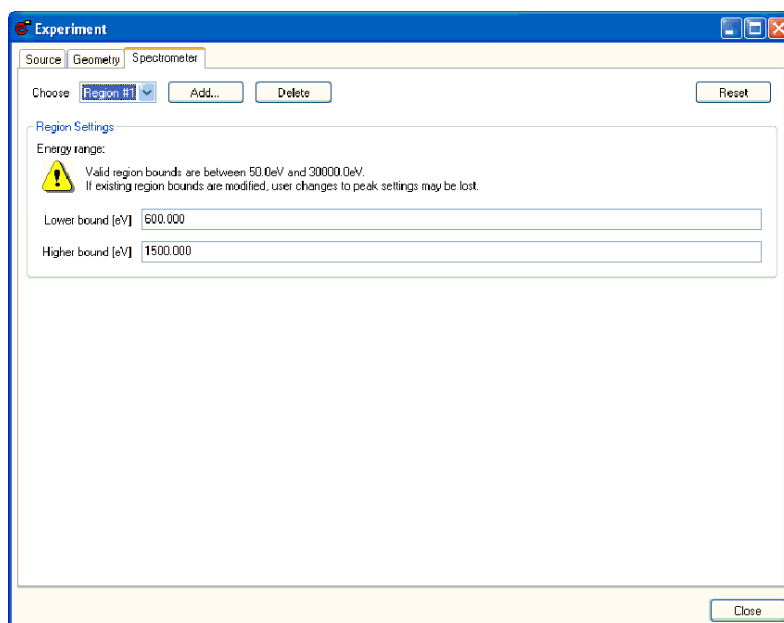Delete the selected spectrometer region.

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Figure 4.9. Graphical user interface for the SPECTROMETER Menu.

3. SPECTROMETER SET ACTREGION <int>
    Set the number of the default spectrometer to which all following
    commands apply by default.

4. SPECTROMETER SET RANGE <string> [REGION <int>]
    Set the range of the spectrometer energy window in eV. For
    example, SPECTROMETER SET RANGE 900:1400 will set the
    energy window to (900:1400). SPECTROMETER SET RANGE 900:
    sets only the lower bound, while SPECTROMETER SET RANGE
    :1400 sets only the upper bound. REGION is the number of the
    selected spectrometer region.

5. SPECTROMETER LIST
    List all regions in the CLI.

6. SPECTROMETER RESET
    Resets the spectrometer settings to default values.

7. SPECTROMETER SHOW SPECTROMETER
    Shows information about the spectrometer in the CLI.

8. SPECTROMETER SHOW REGION <int>
    Shows all information about the specified region in the CLI.

4.7 The GEOMETRY Menu

This menu specifies the experimental geometry, as shown in Fig. 4.10. A number of geometries can be specified. When a model calculation is performed with SESSA (see Section 4.9), a simulation is made for each geometry specified in this menu. For each geometry, the directions of the sample surface normal, the analyzer axis and the orientation of the source of exciting radiation are specified in spherical coordinates in a fixed frame of reference. The analyzer acceptance angle is specified in spherical coordinates in a frame of reference in which the z-axis is parallel to the analyzer axis.
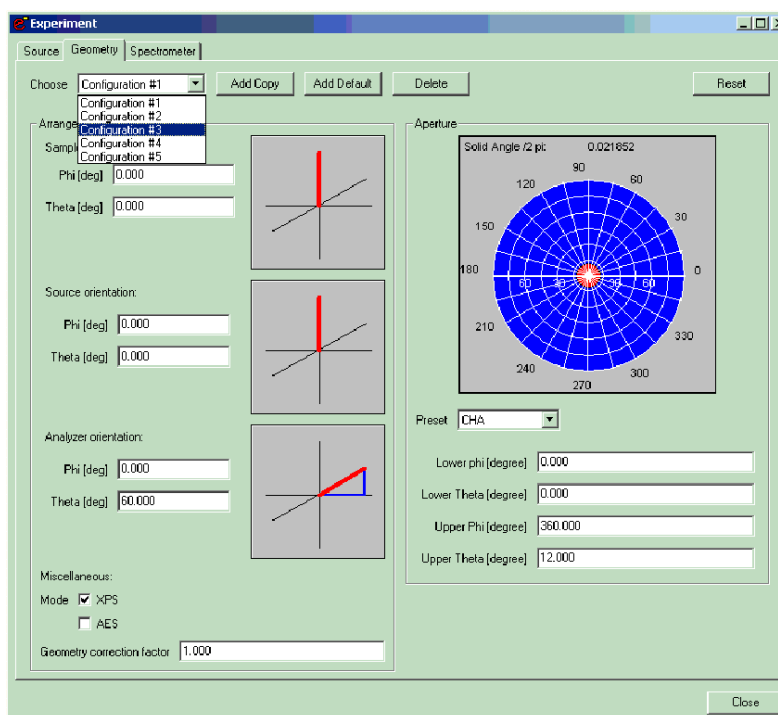

Figure 4.10: Graphical user interface for the GEOMETRY Menu.

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4.7.1 Synopsis of CLI Commands

1. GEOMETRY SET ACTGEO <int>
    Set the number of the default geometry to which all following
    commands apply by default. When the optional parameter [geometry]
    is omitted in any command, it is assumed to apply to the default
    geometry set here.

2. GEOMETRY SET SAMPLE PHI <double> [GEOMETRY <int>]
    Set the azimuthal angle for the sample normal, where GEOMETRY is
    the number of the selected geometry.

3. GEOMETRY SET SAMPLE THETA <double> [GEOMETRY <int>]
    Set the polar angle for the sample normal, where GEOMETRY is the
    number of the selected geometry.[2]

4. GEOMETRY SET SOURCE PHI <double> [GEOMETRY <int>]
    Set the azimuthal angle for the direction of the incoming radiation,
    where GEOMETRY is the number of the selected geometry.

5. GEOMETRY SET SOURCE THETA <double> [GEOMETRY <int>]
    Set the polar angle for the direction of the incoming radiation, where
    GEOMETRY is the number of the selected geometry.[3]

6. GEOMETRY SET ANALYZER PHI <double> [GEOMETRY <int]
    Set the azimuthal angle for the analyzer axis, where GEOMETRY is
    the number of the selected geometry.

7. GEOMETRY SET ANALYZER THETA <double> [GEOMETRY <int>]
    Set the polar angle for the analyzer axis, where GEOMETRY is the
    number of the selected geometry.[3]

8. GEOMETRY SET ANALYZER CMA [GEOMETRY <int>]
    Set the analyzer aperture to that of a standard cylindrical mirror
    analyzer (CMA), where GEOMETRY is the number of the selected
    geometry.

9. GEOMETRY SET ANALYZER CHA [GEOMETRY <int>]
    Set the analyzer aperture to that of a standard concentric
    hemispherical analyzer (CHA), where GEOMETRY is the number of
    the selected geometry.[3]

---

[2] A polar angle in SESSA is always specified by a positive number in the
range 0^o to 180^o, as is usual in a spherical coordinate system; "negative"
polar emission angles are obtained by changing the azimuthal angle by
180^o.

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10. GEOMETRY SET ANALYZER RFA [GEOMETRY <int>]
    Set the analyzer aperture to that of a standard retarding field
    analyzer (RFA), where GEOMETRY is the number of the selected
    geometry.[3]

11. GEOMETRY SET APERTURE LPHI <double> [GEOMETRY <int>]
    Set the lower azimuthal angle of the analyzer aperture, where
    GEOMETRY is the number of the selected geometry.

12. GEOMETRY SET APERTURE UPHI <double> [GEOMETRY <int>]
    Set the upper azimuthal angle of the analyzer aperture, where
    GEOMETRY is the number of the selected geometry.

13. GEOMETRY SET APERTURE LTHETA <double> [GEOMETRY
    <int>]
    Set the lower polar angle of the analyzer aperture, where
    GEOMETRY is the number of the selected geometry.[3]

14. GEOMETRY SET APERTURE UTHETA <double> [GEOMETRY
    <int>]
    Set the upper polar angle of the analyzer aperture, where
    GEOMETRY is the number of the selected geometry.[3]

15. GEOMETRY SET MODE XPS [GEOMETRY <int>]
    Set the geometry mode to XPS. In this mode, the surface area seen
    by the analyzer changes as the inverse cosine of the polar emission
    angle with respect to the surface normal. GEOMETRY is the number
    of the selected geometry.

16. GEOMETRY SET MODE AES [GEOMETRY <int>]
    Set the geometry mode to AES. In this mode, the surface area seen
    by the analyzer is independent of the emission angle. GEOMETRY is
    the number of the selected geometry.

17. GEOMETRY SET FACTOR <double> [GEOMETRY <int>]
    Set a geometric correction factor for each geometry. Geometrical
    artifacts are often difficult to avoid in a real experiment, but are
    usually reproducible for a given instrument. Therefore, a geometry-
    dependent correction factor can be defined here if desired, as
    described in Section 5.2.3. GEOMETRY is the number of the
    selected geometry.

18. GEOMETRY ADD GEOMETRY [COPY <int>]
    Add a geometry to the list for angle-resolved experiments, where
    COPY adds a geometry to the list and copies the parameter values
    for the previous geometry into the new geometry.

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19. GEOMETRY DELETE GEOMETRY <int>
    Delete the selected geometry from the list.

20. GEOMETRY LIST
    List all different geometries.

21. GEOMETRY RESET
    Reset the geometrical configurations to default values.

22. GEOMETRY SHOW [GEOMETRY <int>]
    Show all information for the specified geometry, where GEOMETRY
    is the number of the selected geometry.

4.8 The DATABASE Menu

This menu selects the databases for the various physical quantities used
in SESSA, as shown in Fig. 4.11. The default databases used for retrieval
in the expert system can be selected with this menu. The acronyms for
the physical quantities in Fig. 4.11 are defined in Table 3.3.

4.8.1 Synopsis of CLI Commands

1. DATABASE IMFP SET <string>
   Select a database for retrieval of inelastic mean free path (IMFP)
   values.

2. DATABASE IMFP SHOW
   Show a list of available databases for the IMFP in the CLI.

3. DATABASE DIIMFP SET <string>
   Select a database for retrieval of the differential inverse inelastic
   mean free path (DIIMFP).

4. DATABASE DIIMFP SHOW
   Show a list of available databases for the DIIMFP in the CLI.

5. DATABASE TECS SET <string>
   Select a database for retrieval of the total elastic cross section
   (TECS).

6. DATABASE TECS SHOW
   Show a list of available databases for the TECS in the CLI.

7. DATABASE TRECS SET <string>
   Select a database for retrieval of the transport (elastic) cross section
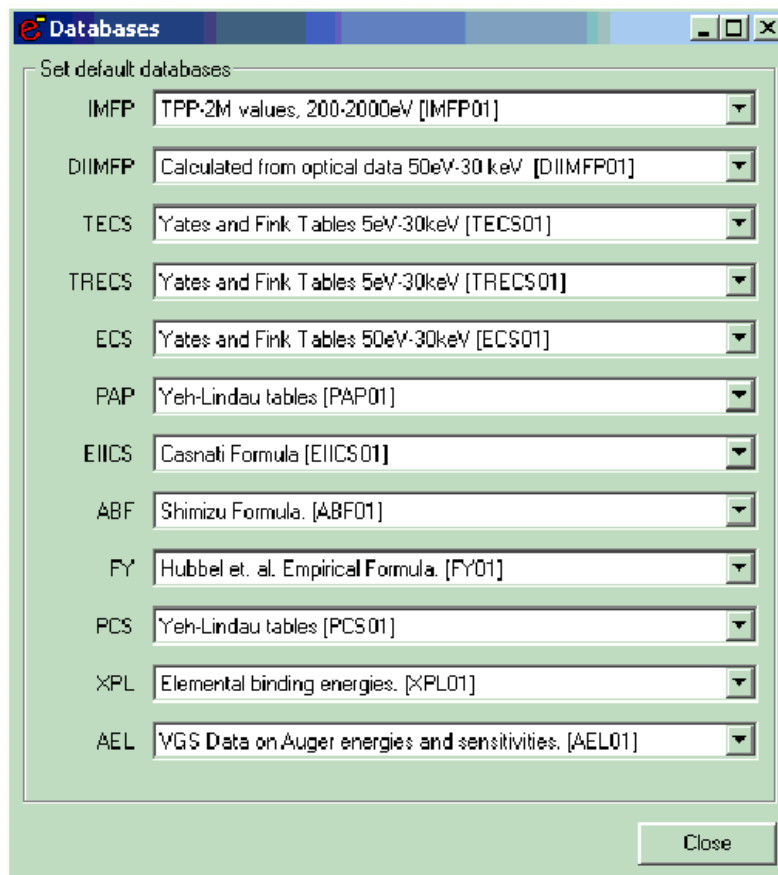   (TRECS).

Figure 4.11. Graphical user interface for the DATABASE Menu.

8. DATABASE TRECS SHOW
   Show a list of available databases for the TRECS in the CLI.

9. DATABASE ECS SET <string>
   Select a database for retrieval of the (differential) elastic cross
   section (ECS).

10. DATABASE ECS SHOW
    Show a list of available databases for the ECS in the CLI.

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11. DATABASE PAP SET <string>
   Select a database for retrieval of the photoionization asymmetry
   parameter (PAP).

12. DATABASE PAP SHOW
   Show a list of available databases for the PAP in the CLI.

13. DATABASE EIICS SET <string>
   Select a database for retrieval of the electron impact ionization cross
   section (EIICS).

14. DATABASE EIICS SHOW
   Show a list of available databases for the EIICS in the CLI.

15. DATABASE ABF SET <string>
   Select a database for retrieval of the Auger backscattering factor
   (ABF).

16. DATABASE ABF SHOW
   Show a list of available databases for the ABF in the CLI.

17. DATABASE FY SET <string>
   Select a database for retrieval of the fluorescence yield (FY).

18. DATABASE FY SHOW
   Show a list of available databases for the FY in the CLI.

19. DATABASE PCS SET <string>
   Select a database for retrieval of the photoionization cross section
   (PCS).

20. DATABASE PCS SHOW
   Show a list of available databases for the PCS in the CLI.

21. DATABASE XPL SET <string>
   Select a database for retrieval of the X-ray photoelectron lineshape
   (XPL).

22. DATABASE XPL SHOW
   Show a list of available databases for the XPL in the CLI.

23. DATABASE AEL SET <string>
   Select a database for retrieval of the Auger electron lineshape (AEL).

24. DATABASE AEL SHOW
   Show a list of available databases for the AEL in the CLI.

25. DATABASE SHOW DATABASE
     Show a list of the databases selected for retrieval/simulation of
     XPS/AES spectra in the CLI.

4.9 The SIMULATION Menu

This menu controls parameters of the simulation, as indicated in Fig. 4.12.
SESSA is able to perform a Monte Carlo simulation of an electron
spectrum based on the parameters retrieved for the specified sample and
for the specified experimental conditions, as described in Ref. [1]. For this
purpose, a number of trajectories that mimic the physics of the electron
transport are generated. The simulation algorithm is very efficient: each
trajectory contributes to all energies in the spectrum. This is achieved by
assigning an *a posteriori* likelihood for *n*-fold scattering to each trajectory.
For each trajectory, a contribution to the so-called partial intensities
is calculated. These quantities represent the probability that a given
electron arrives at the detector after experiencing a given number of
collisions. Multiplying this number with the distribution of energy losses
after a given number of inelastic collisions gives the partial
spectrum of *n*-fold inelastically scattered electrons. Adding up these
contributions gives the total simulated spectrum. Furthermore, the
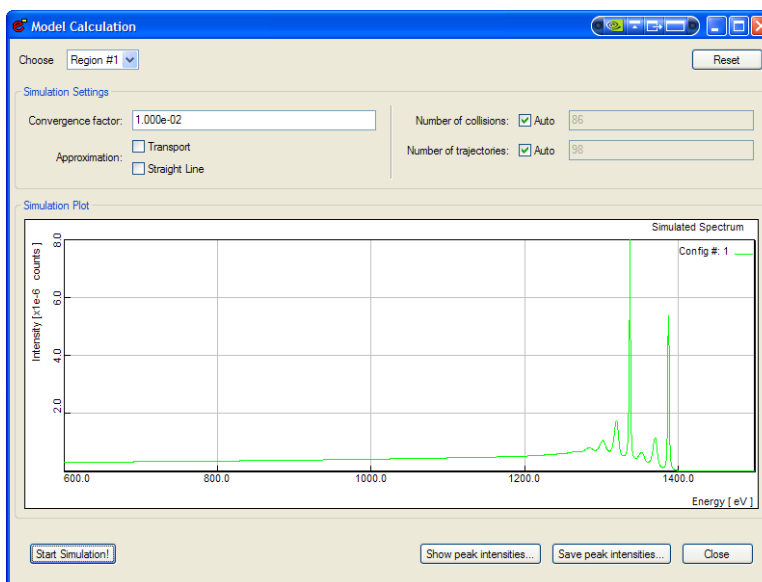trajectory reversal algorithm [8] is used by SESSA. This algorithm allows

Figure 4.12. Graphical user interface for the Simulation Menu.

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a user to perform simulations for a detector with an infinitely narrow opening angle of the analyzer; see Ref. [1] for more details about the simulation procedure.

The maximum number of inelastic collisions ("Number of collisions") is either determined automatically or can be set by the user. The computation time required for a simulation increases with this maximum number, in particular if `ndiimfp = 2` is chosen in the preferences menu (see section 4.3). If only the intensities of the peaks in the spectrum are of interest (electrons escaping without any inelastic collision), the maximum number of collisions can be set to zero. The simulated spectral shape will then be unrealistic, but the peak intensities will be realistic and generated very efficiently. The number of trajectories that is generated is either determined automatically by the convergence criterion, or can be specified by the user (typically 500 for a calculation with 1 % precision).

For illustrative purposes, the user may wish to carry out simulations in various approximations. It is presently possible to choose between three different approaches obtained by employing different distributions of scattering angles and associated mean free paths for successive collisions:

(1) the usual "Mott" cross section for elastic scattering calculated from the relativistic plane-wave expansion method that is believed to provide a realistic description of elastic-scattering events of electrons in solids when used in conjunction with the elastic mean free path derived from it [9, 10];

(2) neglect of elastic deflections (straight line approximation, SLA, or rectilinear motion model), corresponding to an infinite elastic mean free path; and

(3) an isotropic transport cross section taking the transport mean free path as the characteristic length for elastic deflections. The latter approach is essentially equivalent to the so-called transport approximation (TA) [1, 11].

The latter two options choices for the simulation approach can be selected by checking the corresponding boxes labeled Straight Line and Transport in the GUI (Fig. 4.12).

The Show peak intensities and Save peak intensities buttons provide a convenient means of displaying and/or saving the zero-th order partial intensities for the peaks in the spectrum. These operations (that are available for all partial intensities) can also be performed from the Sample Peaks screen (Section 4.4.5).

4.9.1 Synopsis of CLI Commands

1. MODEL SET NCOL <int> [REGION <int]
   Set the maximum number of inelastic collisions to a fixed value,
   where REGION is the number of the selected spectrometer region.

2. MODEL SET NTRAJ <int> [REGION <int>]
   Set number of trajectories used in the simulation to a fixed value,
   where REGION is the number of the selected spectrometer region.

3. MODEL SET TA <string>
   Set TA (transport approximation) to true or false. If TA is set to true,
   an isotropic distribution of polar deflection angles for elastic
   scattering is used in the simulation.

4. MODEL SET SLA <string>
   Set SLA (straight line approximation) to true or false. If SLA is set to
   true, elastic scattering of the signal electrons in the sample is
   neglected.

5. MODEL SET CONVERGENCE <double>
   Set the convergence criterion for the MC simulation. The simulation
   for a given peak terminates when the relative change in the sum of
   all requested partial intensities drops below the criterion for ten
   successive trajectories. So, for example, if the user has set number
   of `collisions = 0`, and the convergence criterion is 0.01, then the
   simulation terminates if the intensity of the no-loss peak changes by
   less than 1% for 10 successive trajectories. The precision of the
   calculation for the peak intensity will then be better than 1%. Note
   that when an entire spectrum is simulated (`number of
   collisions<>0`), the sum of all partial intensities (to which the
   termination criterion applies) is actually the total spectral intensity
   (area under the spectrum) for the considered transition.

6. MODEL AUTO NCOL [REGION <int>]
   Maximum number of inelastic collisions will be automatically
   calculated by the simulation module, where REGION is the number
   of the selected spectrometer region.

7. MODEL AUTO NTRAJ [REGION <int>]
   Number of trajectories will be automatically calculated by the
   simulation module, where REGION is the number of the selected
   spectrometer region.

8. MODEL PLOT [REGION <int>]

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Graphical representation of the simulated spectrum for a given spectrometer region in the separate plot window, where REGION is the number of the selected spectrometer region.

9. MODEL SIMULATE
   Perform a Monte Carlo simulation of the spectral shape using the given settings for all relevant parameters.

10. MODEL SHOW
    Show information on parameters controlling the simulation.

5 RETRIEVAL STRATEGY AND SIMULATION MODEL

5.1 Retrieval strategy of the expert system

In a first step, the expert system establishes the relevant peaks in accordance with the user's specification of the sample composition and the selected excitation source and spectrometer settings. This is done by looking up the source energy and the type of exciting radiation (photons, electrons) and querying the databases for the peak shapes for each element in all layers of the sample. When a peak is found that is not present in the internal peak list, and falls within any of the specified spectrometer regions, the peak is added to the peak list. This peak list is on display in the "Sample/Peaks" menu in the GUI and can be listed via the corresponding command in the CLI.

The energy distribution for a useful peak in an AES or XPS spectrum for a solid is known to be sharply peaked with respect to the nearby background. However, the total energy range where the emission probability assumes non-vanishing values can generally be very broad. In order to decide whether a peak should be taken into account in a given spectrometer region, it is therefore necessary to invoke some meaningful criterion. In the SESSA expert system this is done by comparing the fraction of the peak area that falls within the considered spectrometer energy region with the threshold parameter. If this fraction exceeds the threshold value specified by the user (see Section 4.3), the peak is included; otherwise it is discarded from the peak list.

If a given element is present in more than one chemical state, each peak for this material is added in duplicate to the peak list, and is accordingly labeled. While the main purpose of the chemical-state label is indeed to indicate the chemical states of a given element in order for the software to be able to differentiate between them, it is to be noted that the chemical state label is nothing but an arbitrary label allowing such a distinction to be made. In other words, it can just as well be used for an entirely different purpose, e.g., to simulate the excitation depth distribution in

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some special applications of electron spectroscopy (see, for example, Section 7.3.1).

After the relevant peaks have been established in this way, the parameters for the generation of the associated signal electrons are retrieved from the corresponding databases together with the parameters describing the characteristics of the electron-solid interaction (or, in other words, the surface sensitivity) are obtained from the relevant databases.

As mentioned before, an essential aspect of the expert system, in particular in conjunction with a simulation module, is that for each considered electronic transition leading to the emission of signal electrons, all parameters concerning their generation and interaction with the solid *must* be known; otherwise the software will eventually be unable to take meaningful decisions and to provide meaningful results (i.e., the software would cease to run). This situation is, of course, completely unacceptable, and the databases must therefore be able to return at least a credible estimate for each queried quantity. As explained in Section 3.1, SESSA is designed always to provide a backup database that is extensive. The reliability of the returned datum from the backup database is, of necessity, not always comparable to the typical reliability of the other databases. Nevertheless, the fact that each datum is traceable to its source in the scientific literature (see also Section 6) makes the individual reliability of any datum accessible to the user, while the overall reliability of, for example, the outcome of a simulation of SESSA can be assessed in survey form by inspection of the files ending with `rems.txt` and `refs.txt` (see Section 3.4).

5.2 Algorithm for spectrum simulation

When all needed parameters have been retrieved from the databases, a simulation of the expected outcome of the specified experiment can be performed with SESSA. The simulation algorithm is based on the partial intensity approach for the electron-solid interaction [1, 12, 13,14, 15]. The key quantities in this approach are the so-called partial intensities that describe the number of electrons arriving at the detector after having participated in a given number of inelastic collisions in the solid between their point of generation and escape from the surface. In SESSA, the partial intensities are calculated with a very efficient Monte Carlo calculation based on the so-called trajectory reversal algorithm [8] that benefits from a symmetry property of the (linearized) Boltzmann kinetic equation which forms the basis of the surface sensitivity of electron-beam techniques for non-crystalline solids. In the following sections, the simulation algorithm is described in some detail in order for a user to be able to understand and interpret the results of a simulation.

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In the range of medium energies (50 eV to 20 keV) for which SESSA is designed, the characteristics of the electron-solid interaction allow some drastic simplifications to be made leading to a convenient starting point of the theory. In particular, a clear distinction can be made between multiple inelastic scattering and multiple elastic scattering. While inelastic scattering can be treated in a straightforward manner by means of an analytic theory, elastic scattering is most conveniently tackled by means of a numerical approach. The Monte Carlo technique employed by SESSA is the most flexible numerical technique with respect to the boundary conditions of the considered problem.

5.2.1 The electron spectrum in AES/XPS

The objective of SESSA is to facilitate interpretation of the spectra of electrons that are generated by means of electron or photon bombardment in the near -surface region of a solid, escape from the surface, and are analyzed and detected by a spectrometer. Obviously, the quantities relevant for the relevant processes and, in particular, any eventual relationship between them need to be studied before establishing a theory describing the phenomenon. A detailed discussion of the physical quantities describing signal-electron generation and transport is beyond the scope of this Guide, and the reader is referred to reviews in the literature (e.g., Refs. [1, 16, 17]).

The most important facts may be summarized as follows:

- For any given electronic transition, the energy and angular distributions are uncorrelated; i.e., the energy distribution of electrons liberated at an atom in a solid is the same for all emission directions. Since the depth distribution of the emitting sources is determined by the compositional depth profile of the specimen, we expect that the source angular, energy and depth distributions will be uncorrelated.

  The source distribution $S_0(E, z, \vec{\Omega})$ can then be factored into energy- $(f_0(E))$, angular- $(g_0(\vec{\Omega}))$, and depth- $(c_0(z))$ dependent terms:

$$S_0(E, z, \vec{\Omega}) = f_0(E) \times g_0(\vec{\Omega}) \times c_0(z) \qquad (5.1)$$

  Here $\vec{\Omega} = (\theta, \varphi)$ is a shorthand notation for the electron emission direction, specified by the polar angle θ and the azimuthal angle φ.

- The electron-solid-interaction characteristics for the electron transport (mean free paths, cross sections, etc.) are not strongly

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dependent on energy. More precisely, the change in any interaction characteristic is small compared to the value of that quantity when the energy changes by an amount ΔE corresponding to a typical energy loss $<T> \approx e^2 / a_0 = 27.2$ eV in an inelastic collision, where e is the electronic charge and a_0 is the Bohr radius. We then have:

$$\frac{\Delta \lambda}{\lambda} << \frac{\Delta E}{<T>} \tag{5.2}$$

where λ stands for any of the interaction characteristics.

- The width of the energy distribution for a useful peak in an AES or XPS spectrum is small compared to the typical energy loss in an inelastic collision.

- Energy losses and deflections can be regarded as independent processes.

The above conditions are generally fulfilled in AES and XPS [1] and allow one to immediately understand the so-called partial intensity approach for the theoretical description of an electron spectrum, without resorting to complicated mathematical derivations. Readers interested in a rigorous mathematical treatment of the problem are referred to Ref. [17].

It is obvious that each electron leaving the surface has experienced a given number, say n = 0, 1, 2, … , of inelastic collisions. In other words, the emerging spectrum consists of groups of electrons that have experienced a certain number of inelastic processes. Since the energy and angular distributions in the source function $S_0(E, z, \vec{\Omega})$ factorize into energy and angular terms, and since elastic (deflections) and inelastic collisions (energy losses) may be assumed to occur independently, it follows that each of the groups of n-fold inelastically scattered electrons is also a product of a function $F_n(E)$ depending only on the energy and a function $C_n(\vec{\Omega})$ that depends only on the emission direction. Taking the energy distribution of the n-th group, the so-called partial energy distribution, to be normalized, $\int F_n(E) dE \equiv 1$, the partial intensities $C_n(\vec{\Omega})$ are identified as the *number* of electrons in the corresponding group. Since the energy dependence is assumed to be sufficiently weak, it follows that the interaction characteristics within each group can be taken to be the same and, furthermore, since the energy distribution at the source is narrow compared to the typical energy loss, the transfer

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processes determining the surface sensitivity are the same for all electrons within a given peak.

Summing up the different groups gives the spectrum $Y(E, \vec{\Omega})$:

$$Y(E, \vec{\Omega}) = \sum_{n=0}^{n_{max}} C_n(\vec{\Omega}) F_n(E) \qquad (5.3)$$

In this expression, n_{max} is the largest order of inelastic scattering considered. In SESSA, this parameter can be automatically determined, by clicking the Auto box in front of the "number of inelastic collisions" field in the Simulation menu, or it can be set by the user. The latter option is convenient, e.g., when only the intensity of the peak of no-loss electrons is of interest since this intensity can then be calculated very efficiently (see Section 5.2.3). The remaining problem is to find a convenient means of evaluating the partial energy and intensity distributions, as described in the next two Sections.

5.2.2 Multiple inelastic scattering: the partial energy distributions

Since the transport equation is linear, it is straightforward to express the distribution of energy losses after a given number of inelastic collisions in terms of the source energy distribution $f_0(E)$ if the energy-loss distribution in a single inelastic collision $w(T)$ is known. The latter quantity is, of course, identical to the (normalized) differential inelastic inverse mean free path for which a database is available in SESSA.

Let us assume that the source energy distribution $f_0(E)$ is normalized to unity area. The probability that an Auger-electron or photoelectron is emitted by an atom in the sample with an energy between $E+T$ and $E+T+dT$ is then given by $f_0(E+T)dT$. Multiplying this probability with the probability for an energy loss in the interval $(T, T+dT)$ gives the probability that the electron has the energy E after experiencing a single inelastic collision. Integrating over all different possible values of the energy loss T gives the energy distribution after one energy loss as:

$$F_1(E) = \int f_0(E+T) w(T) dT \ . \qquad (5.4)$$

In exactly the same way, the higher-order loss distributions may be calculated. The whole procedure may be summarized by the recurrence relations:

$$F_n(E) = \int F_{n-1}(E+T)w(T)dT$$

$$= \int f_0(E+T)L_{n-1}(T)dT \ . \tag{5.5}$$

In the second line of this equation, the partial loss distributions $L_n(T)$, i.e., the distribution of energy *losses* after n inelastic collisions, is introduced.

When more than one inelastic-scattering distribution is of relevance for the considered problem (e.g., when the inelastic-scattering properties are significantly different in the two topmost layers of the sample), the above equations can be generalized as follows:

$$F_{n1,n2,n3,\dots}(E) = \int F_{n1-1,n2,n3,\dots}(E+T)w_1(T)dT$$

$$= \int F_{n1,n2-1,n3,\dots}(E+T)w_2(T)dT$$

$$\dots, \tag{5.6}$$

where $w_1(T)$ is the distribution of energy losses for the first layer, etc. In the present version of SESSA, it is possible to distinguish between two different inelastic-scattering distributions, $w_1(T)$ and $w_2(T)$, by setting the parameter NDIIMFP to two. One inelastic-scattering distribution ($w(T)$) is set as the default (NDIIMFP=1) (see Section 4.3).

5.2.3 Multiple elastic scattering: the partial intensities

The partial intensities $C_n(\vec{\Omega}_i, \vec{\Omega}_e)$, i.e., the number of signal electrons arriving at the detector, depend on several experimental parameters such as the flux of exciting radiation, the spectrometer transmission etc., as well as on the source depth distribution of the emitting species $c_0(z)$ (where $c_0(z)$ represents the atomic fraction of an element at a given depth z), the probability that a transition takes place at a certain depth, the so-called excitation depth distribution function $\phi_x(z, \vec{\Omega}_i, \vec{\Omega}_x)$, and the probability for escape after n inelastic collisions that is described by the emission depth distribution function $\phi_{e,n}(z, \vec{\Omega}_x, \vec{\Omega}_e)$:

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$$C_n(\vec{\Omega}_i, \vec{\Omega}_e) = DAFTN_a \int\limits_{\Delta\Omega} \int\limits_{4\pi} \int\limits_0^\infty \phi_x(z, \vec{\Omega}_i, \vec{\Omega}_x) c_0(z)$$

$$\times \phi_{e,n}(z, \vec{\Omega}_x, \vec{\Omega}_e) dz d\vec{\Omega}_x d\vec{\Omega}_e. \qquad (5.7)$$

The subscripts x and e are used here to denote the excitation and emission processes, respectively, and $\vec{\Omega}_x$ and $\vec{\Omega}_e$ are the emission directions of the signal electrons at the source and after emission from the surface. In Eq. (5.7), D denotes the detector efficiency, T is the spectrometer transmission, F is the flux of the exciting radiation, N_a is the atomic density, and A is the analyzed area. The latter variable is obviously determined by the experimental geometry and, in particular, depends on whether the area seen by the analyzer exceeds the excitation area on the sample. In this case, the analyzed area is independent of the emission angle, whereas for the opposite case when the illuminated area is much larger than the area seen by the analyzer, the analyzed area varies with the polar emission angle as $A \propto 1/\cos\theta_e$. The latter situation corresponds to the XPS mode in the Geometry menu of SESSA (see Section 4.7) while the former corresponds to the AES mode; note, however, that the AES mode could be applicable to XPS instruments in which the incident X-rays are focused to a relatively small area. It is also important to recognize that perfect alignment of the beam of primary radiation and the analyzer is not always achievable in measurements of angular distributions, in which case geometrical artifacts can arise in the measured angular distributions. Sometimes, measurements can be made of the relevant calibration factors. These calibration factors, if known, can be entered for a given geometry in the geometry correction factor box of the Geometry menu.

The term $\Delta\Omega$ in Eq. (5.7) represents the solid angle of acceptance of the analyzer over which the emitted spectrum needs to be integrated. The magnitude of the acceptance solid angle is indicated in the Geometry menu by specifying the upper and lower values of the polar and azimuthal angles (θ and ϕ). The factors D, F, and T in front of the integrals in Eq. (5.7) are taken to be unity in the present implementation of SESSA.

A further simplifying assumption made in the simulation is that the excitation depth distribution function $\phi_x(z, \vec{\Omega}_i, \vec{\Omega}_x)$ varies only very slowly with depth. This quantity can then be taken outside the depth integral and replaced by the electron-production cross section $\sigma_{ex}(\vec{\Omega}_i, \vec{\Omega}_x)$. In an XPS experiment this production cross section is

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equal to the photoionization cross section $\sigma_{ph}(\vec{\Omega}_i,\vec{\Omega}_x)$. In AES, the production cross section is independent of $\vec{\Omega}_x$ and is given by the product of the electron-impact ionization cross section σ_{ei} and the Auger backscattering factor $(1+r_A(\vec{\Omega}_i))$, that accounts for the additional ionization of the considered subshell through backscattered primary electrons, and the probability that the core hole is filled via the considered Auger electron transition, indicated here with ω_A so that

$\sigma_{ex}=\sigma_{ei}\omega_A(1+r_A(\vec{\Omega}_i))$. In the present version of SESSA, the angular dependence of the excitation depth distribution is also simplified. in the case of AES, the dependence on $\vec{\Omega}_i$ is assumed to follow Shimizu's expression [18], while the emission angular distribution at the source is taken to be isotropic. For XPS, it is assumed that the direction of incidence at the location of signal-electron generation is identical to the incident direction of the X-rays on the surface, i.e., deflections of photons in the solid and at the surface are neglected. Taking into account the above assumptions and collecting all constant terms into a new constant *K*, the partial intensities can be written as:

$$C_n(\vec{\Omega}_i,\vec{\Omega}_e)=K\int_{\Delta\Omega}\int_{4\pi}\int_0^\infty\sigma'_{ex}(\vec{\Omega}_i,\vec{\Omega}_x)c_0(z)\phi_{e,n}(z,\vec{\Omega}_i,\vec{\Omega}_e)dzd\vec{\Omega}_i d\vec{\Omega}_e,$$

(5.8)

where $\sigma'_{ex}(\vec{\Omega}_i,\vec{\Omega}_x)$ represents the normalized angular part of the production cross section.

The emission depth distribution function $\phi_{e,n}(z,\vec{\Omega}_i,\vec{\Omega}_x)$ represents the probability for signal-electron escape from a given depth after experiencing a given number *n* of inelastic collisions. The probability for *n*-fold scattering, on the other hand, depends on the electron pathlength inside the solid. Due to elastic scattering, not all electrons travel the same pathlength; instead, the pathlengths *s* are distributed according to a function $Q(z,s,\vec{\Omega}_x,\vec{\Omega}_e)$. In other words, the depth distribution function can be expressed in terms of this pathlength distribution function and the probability for *n*-fold scattering as a function of the traveled pathlength $W_n(s)$ [12]; the latter function is given by the Poisson distribution when the interaction characteristics are assumed to be independent of the energy. The latter approach, known as the quasi-elastic approximation [1, 12, 16, 19], is adopted in SESSA and is valid when the considered

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energy-loss range is small compared to the signal-electron energy. The emission depth distribution can be written as:

$$\phi_{e,n}(z,\vec{\Omega}_x,\vec{\Omega}_e) = \int_0^\infty Q(z,s,\vec{\Omega}_x,\vec{\Omega}_e)W_n(s)ds \; . \tag{5.9}$$

Using this result, Eq. (5.8) can be transformed as follows:

$$C_n(\vec{\Omega}_i,\vec{\Omega}_e) = K \int_{\Delta\Omega} \int_{4\pi} \int_0^\infty \int_0^\infty \sigma'_{ex}(\vec{\Omega}_i,\vec{\Omega}_x)c_0(z)Q(s,z,\vec{\Omega}_x,\vec{\Omega}_e)$$

$$\times W_n(s)dz d\vec{\Omega}_i d\vec{\Omega}_e ds \; . \tag{5.10}$$

The distribution of pathlengths represents a quantity that is ideally suited for calculation with the Monte Carlo (MC) technique since, with this approach, a large set of trajectories is simulated. By making a histogram of the lengths of such a set of trajectories, the pathlength distribution is immediately obtained. In SESSA, the integral in Eq. (5.10) is therefore calculated by means of the MC technique. The MC simulation is based on the very efficient trajectory reversal algorithm [8] which in turn is based on a symmetry property of the Boltzmann kinetic equation, the so-called reciprocity theorem (see e.g., Ref. [20]). This theorem states that, for a quasi-elastic trajectory, the source point and the termination point of a trajectory are equivalent. In other words, instead of simulating a trajectory from its source point through the solid and hoping that this electron is emitted from the surface with the correct direction to be detected by the analyzer (which, depending on the magnitude of the acceptance solid angle of the analyzer, is not likely to be the case for the overwhelming majority of all trajectories), one can also start the simulation at the analyzer and trace back the path of the electron inside the solid. In this way, a significant increase in efficiency of an MC calculation is obtained that makes it possible to perform simulations of this kind on a personal computer.

The generation of trajectories proceeds in the usual way by means of the Monte Carlo technique. More details can be found in Ref. [1]. The user has a choice among three different types of elastic-scattering cross sections for a simulation:

1. The "Mott" cross section for elastic scattering derived from the relativistic plane-wave expansion method. This choice is believed to give the most reliable results [62], and is recommended for most applications.

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2. The isotropic transport cross section. This choice (made by checking the Transport box in the Model menu of Fig. 4.12) allows a faster simulation of the trajectories and gives excellent results when the conditions of the so-called generalized radiative field principle are met [11]. The use of the transport cross section corresponds to making the transport approximation that is often used in the analytic treatment of such problems [1]. The transport cross section is one of a few types of cross section for which the transport equation can be solved analytically.

3. A forward-peaked delta-function-shaped "cross section" representing the rectilinear-motion model or straight-line approximation (SLA). This choice (made by checking the Straight Line box in the Model menu of Fig. 4.12) allows a user to study the magnitude of elastic-scattering effects in a given application (i.e., by comparing results from this choice with results of a similar simulation made using the Mott cross section).

In SESSA, the efficiency of the trajectory-reversal algorithm is further enhanced by directly calculating the partial intensities, rather than first calculating the pathlength distribution and then integrating this distribution. Furthermore, the method of statistical weights is used to account for the angular and depth dependences of the source function. To appreciate the former statement, note that the integrals in Eq. (5.9) and Eq. (5.10) can be calculated immediately along each trajectory, instead of first making a histogram and then later performing the integrations. The integral in Eq. (5.10) can thus be solved by directly summing the contributions to the partial intensities $(\Delta C_n)_k$ corresponding to the k-th linear step between two deflections in the MC algorithm as follows:

$$(\Delta C_n)_k (\vec{\Omega}_i, \vec{\Omega}_e) = k \int_{s_k}^{s_k + \Delta s_k} W_n(s) \sigma'_{ex} (\vec{\Omega}_i, \vec{\Omega}_{x,k}) c_0 (z(s)) ds . \qquad (5.11)$$

Here s_k is the pathlength traveled in the solid before the k-th step and Δs_k is the length of the k-th step. The second and third factors in the integral account for the angular and depth dependences of the source function. Assigning the appropriate weight factors for the source distribution in this way in an MC algortihm is known as the method of statistical weights. The integral in Eq. (5.11) can be evaluated analytically, leading to an additional enhancement of computational speed.

After a sufficiently large set of trajectories has been obtained in this way, the partial intensities are finally obtained as:

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$$C_n(\vec{\Omega}_i, \vec{\Omega}_e) = \frac{1}{N_{traj}} \sum_{j=0}^{N_{traj}} \sum_{k=0}^{N_k} (\Delta C_n)_{k,j} (\vec{\Omega}_i, \vec{\Omega}_e),$$ (5.12)

where N_{traj} is the number of trajectories and N_k is the number of steps per trajectory. The value of N_k is determined by the termination criterion. When the total pathlength of a trajectory exceeds a pathlength given by the following function of the inelastic mean free path λ_i and the order of partial intensities n_{max} considered,

$$s > 2\lambda_i (n_{max} + 5),$$ (5.13)

the trajectory is terminated.

The total number of trajectories, N_{traj}, in Eq. (5.12) is determined by the convergence criterion. If the fractional change of the sum of all considered partial intensities is below the convergence factor (provided in the Model menu of Fig. 4.12), generation of trajectories is terminated. The sum of all partial intensities is, of course, identical to the total spectral intensity of a peak (i.e., the area of the peak and its associated inelastic background). Note that for the case of a thin layer on a substrate, the partial intensities decrease rapidly with the order of inelastic scattering. On a logarithmic display, the dependence of the simulated partial intensities on the number of inelastic collisions may then exhibit oscillations. These oscillations are caused by the fact that the higher-order partial intensities contribute only negligibly to the total spectral intensity; these oscillations are thus an artifact of the convergence of the simulation. As an alternative means to control the convergence behavior of the algorithm, the user may directly specify the number of trajectories in the Model menu of Fig. 4.12. A convergence factor of 0.01 will be satisfactory for many applications.

A final aspect of the simulation that should be mentioned here is the fact that the vacuum-solid interface is generally assumed to be atomically flat in SESSA. The only other surface morphology, apart from this idealized concept of an atomically flat surface, is a rough surface. The surface roughness can be specified by a user in SESSA by setting the value of the relative surface area (RSA) in the Sample menu of Fig. 4.5. The RSA is a measure for the surface roughness in terms of the ratio of the real surface area divided by the projected surface area, i.e., the area of the idealized flat surface.

5.3 Current limitations of databases and simulation

It was shown in the previous Section that three quantities need be known for a realistic simulation of the energy and angular distributions: (1) the partial intensities; (2) the source energy, angular and depth distributions;

and (3) the differential inelastic inverse mean free path (see Eqs. (5.3) and (5.5). The additional parameters needed for a simulation of the partial intensities are: the total inelastic mean free path, the differential elastic-scattering cross section, the total elastic-scattering cross section (or, alternatively the transport cross section if the transport approximation is used), the photoionization cross section, the photoionization asymmetry parameter, the electron-impact ionization cross section, the fluorescence yield, and the Auger-electron backscattering factors. For all of these quantities, SESSA contains reasonably reliable data in its databases, while the simulation algorithm for the partial intensities, described above, has also proven satisfactory. Comparison of peak intensities with experimental results exhibit close agreement (see Sections 7.1.1-7.1.4). This situation is generally the case for the intensity of those electrons that escape without being inelastically scattered. It should be emphasized again that the area of the no-loss peak is identical to the zero-order partial intensity, while the higher-order partial intensities describe the spectral intensity in the inelastic background.

For the distribution of energy losses in an inelastic process (i.e., the differential inverse inelastic mean free path), there exists a limited number of materials for which optical data are available that allow a detailed calculation of this quantity. For all other materials, Tougaard's universal cross section is used as a backup data source that gives a reasonable estimate of the overall shape of the loss distribution, but does not describe the fine details of the inelastic excitation probability of a solid. Furthermore, surface and intrinsic excitations [1, 16] are entirely neglected in the present version of SESSA.

The main limitation in the simulation of the spectral *shape* (as opposed to the spectral *intensity*) is the fact that the shape of the energy distribution for inelastic scattering in solids is generally quite complex and a comprehensive database for this quantity, that *must* be based on empirical data, is presently not available within SESSA nor, for that matter, anywhere else in convenient form. Presently, the lineshape of an XPS peak is approximated. After looking up the specified binding energy in a database for elemental binding energies (containing accepted values for binding energies), a default lineshape is chosen for each peak. This default lineshape is a Lorentzian with a full width at half-maximum (FWHM) of 1.4 eV. For AES, the situation is much more complex, since AES peaks can be very broad and consist of many subpeaks. At present, lineshape information for a limited number of Auger peaks is available in the AEL database in SESSA. The only stored data for these peaks are the kinetic energy of the transition, the subshell where the initial ionization took place, and an empirical sensitivity factor. The latter is needed since extensive knowledge of the probability for emission of the considered Auger electrons requires knowledge not only of the relevant fluorescence yields but also of applicable Coster-Kronig transition probability. Sufficient

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data for Coster-Kronig probabilities of the needed reliability are not now available. An empirical sensitivity factor is therefore used to estimate the peak intensity of an Auger transition. The lineshape is again chosen by default to be a Lorentzian with a FWHM of 6.0 eV. The default choice of a Lorentzian lineshape is reasonable in many cases for XPS but is hardly ever a realistic choice for an Auger transition.

These considerations indicate that a user interested in directly comparing experimental lineshapes with results of a SESSA simulation should provide information on the source energy distribution in the SAMPLE PEAK menu of Fig. 4.7. An example further clarifying this problem is given as a tutorial in Section 7.2.2.

Summarizing, the main limitations of the simulation algorithm are that surface and intrinsic excitations are neglected and that the excitation depth distribution function is assumed to be constant inside the specimen. Furthermore, the assumption of an atomically flat surface restricts the applicability of SESSA to practical cases where the surface morphology is not expected to influence the spectral intensities. As far as the databases are concerned, the most important lack of data concerns the empirical peak shapes of photoelectron and Auger-electron transitions and comprehensive data on the Coster-Kronig transition probabilities.

6 PHYSICAL DATA IN SESSA

A large amount of data is needed to interpret an Auger-electron or photoelectron spectrum quantitatively. The required data include basic physical information on the solid in question (density, atomic number of the constituent atoms, etc.), information on the process of creating the signal electrons (photoelectric effect and Auger-electron emission) as well as the various parameters governing the interaction of the signal electrons with the solid on their way out of the specimen. The number of required physical parameters can therefore be large for a particular situation. The SESSA databases provide an extensive and fully traceable dataset for these parameters. The energy range for which data are available extends from 50 eV up to 20 keV.

An extensive dataset for all relevant physical parameters is a strict prerequisite for proper operation of the expert system. On the other hand, it is obvious that not all physical parameters are available for all materials with the same accuracy or, for that matter, are available at all for any arbitrary material. This situation implies that in cases where there are gaps in the data sets, these must be complemented by some credible estimate for the quantity in question. This in turn means that it is generally impossible to make an overall statement on the reliability of the data retrieved by SESSA. It is therefore essential for the data to be fully traceable. Every individual datum retrieved by SESSA is accompanied by

a full reference to the literature and in many cases also contains a statement concerning its reliability. The easiest way for the user to assess the overall quality of the retrieved data is to copy these data to disk. Two of the files produced in this way (filenames ending with `refs.txt` and `rems.txt`) contain a list with statements on the reliability of the retrieved data (see Section 3.4).

The physical quantities for a particular spectrum generally depend on a number of parameters (material, atomic number, energy, etc.). The range of these parameters for which each quantity is available is determined by the selected choice for the data source. For example, the differential inverse inelastic mean free path (DIIMFP) from optical data can only be provided by Penn's algorithm [21] (which is generally regarded as providing the most reliable results for this quantity) for those materials for which energy-loss functions are available in the literature. However, the backup source for this parameter, Tougaard's empirical DIIMFP [7], provides a universal approximate description for the energy-loss probability in a single inelastic collision. The primary and backup sources for this quantity together are generally extensive in that they cover the entire range of parameters of relevance for AES and XPS. This strategy is generally also followed for other parameters. For each quantity for which the primary (most reliable) source does not completely cover the relevant range, the backup source (usually an approximate empirical expression) is extensive, or vice versa.

6.1 Databases used in SESSA

The quantities available in SESSA databases as well as their sources are indicated in the following list.

1. Elemental data (Chemical symbol, chemical name, elemental density (if available), number of valence electrons, atomic weight, atomic electronic configuration, etc.). Source: Refs. [22, 23].

- Keys: Material, Atomic number
- Range: Atomic Number 1-94

2. Differential inverse inelastic mean free path (DIIMFP)

(a) Source: Calculated [24] using linear response theory with the algorithm developed by Penn [21] and using optical data in Refs. [25, 26, 27][3]

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[3] The authors would like to thank Dr. S. Tanuma (National Institute for Materials Science, Tsukuba, Japan) for providing his set of optical loss functions for use in SESSA.

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- Keys: Material, Energy (eV), Energy Loss (eV)
- Range: Materials restricted by availability of source data; Energy: 50 eV to 20 keV

(b) Source: Universal DIIMFP curve proposed by Tougaard [7]

- Keys: Energy Loss (eV)
- Range: Universal

3. Total inelastic mean free path (IMFP)

(a) Source: Empirical IMFP expression (TPP-2M) [6, 28, 29, 30, 31]

- Keys: Material, Energy (eV)
- Range: Material: Universal; Energy: 50 eV to 2000 eV

(b) Source: IMFP values for a selected set of materials calculated by Tanuma, Powell and Penn [6, 28, 29, 30, 31] using optical data

- Keys: Material ID, Energy (eV)
- Range: Material: Restricted to those materials for which optical data are available and iMFPs calculated; Energy: 50 eV to 2000 eV

(c) Source: IMFP values for a selected set of materials calculated using optical data and a quadratic dispersion [24]

- Keys: Material ID, Energy (eV).
- Range: Material: Selected materials for which optical data are available; Energy: 50 eV to 2000 eV

4. Differential elastic-scattering cross section (ECS)

a) Source: Values computed by the program of Yates [32] using the relativistic partial-wave expansion method based on atomic Thomas-Fermi-Dirac (TFD) potentials [33, 62]

- Keys: Atomic Number, Energy (eV)
- Range: Atomic number: 1-99; Energy: 50 eV to 20 keV

(b) Source: NIST SRD 64, V 3.1, Electron elastic-scattering cross-section database. Values computed using the relativistic partial wave expansion method based on atomic Dirac-Hartree-Fock (DHF) potentials [62, 67] as used for the NIST Electron Elastic-Scattering Cross-Section Database (SRD 64) [34]. The cross sections obtained from DHF potentials are

believed to be more reliable than those obtained from TFD potentials
[62].[4]

- Keys: Atomic Number, Energy (eV).
- Range: Atomic number: 1-92; Energy: 50 eV to 20 keV

5. Total elastic-scattering cross section (TECS)

(a) Source: Values computed by the program of Yates [32] using the
relativistic partial-wave expansion method based on atomic TFD
potentials [33, 62]

- Keys: Atomic Number, Energy (eV)
- Range: Atomic number: 1-99; Energy: 50 eV to 20 keV

(b) Source: NIST SRD 64, V 3.1, Electron elastic-scattering cross-section
database. Values computed using the relativistic partial wave expansion
method based on atomic Dirac-Hartree-Fock (DHF) potentials [62, 67] as
used for the NIST Electron Elastic-Scattering Cross-Section Database
(SRD 64) [34]. The cross sections obtained from DHF potentials are
believed to be more reliable than those obtained from TFD potentials
[62].[4]

- Keys: Atomic Number, Energy (eV)
- Range: Atomic number: 1-92; Energy: 50 eV to 20 keV

6. Transport scattering cross section (TRCS)

(a) Source: Values computed by the program of Yates [32] using the
relativistic partial-wave expansion method based on atomic TFD
potentials [33, 62]

- Keys: Atomic Number, Energy (eV)
- Range: Atomic number: 1-99; Energy: 50 eV to 20 keV

(b) Source: NIST SRD 64, V 3.1, Electron elastic-scattering cross-section
database. Values computed using the relativistic partial wave expansion
method based on atomic Dirac-Hartree-Fock (DHF) potentials [62, 67] as
used for the NIST Electron Elastic-Scattering Cross-Section Database

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[4] The authors would like to thank Prof. A. Jablonski (Institute of Physical
Chemistry, Polish Academy of Sciences, Warsaw, Poland) for providing
calculated differential elastic-scattering cross sections, total elastic-
scattering cross sections, and transport scattering cross sections for use
in SESSA.

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(SRD 64) [34]. The cross sections obtained from DHF potentials are believed to be more reliable than those obtained from TFD potentials [62].[4]

- Atomic Number, Energy (eV)
- Range: Atomic number: 1-92; Energy: 50 eV to 20 keV

(c) Source: Tilinin's quasi-classical expression [35]

- Keys: Atomic Number, Energy (eV)
- Range: universal

7. Photoionization cross section (PCS)

(a) Source: Values computed by Scofield for Mg and Al Kα X-rays [36]

- Keys: Atomic Number, Subshell ID, Photon Energy (eV)
- Range: Atomic number: 1-96; Subshells: extensive; Photon Energy: Mg and Al Kα X-rays

(b) Source: Values computed by the program of Yeh and Lindau [37]

- Keys: Atomic Number, Subshell ID, Photon Energy (eV)
- Range: Atomic number: 1-96; Subshells: extensive; Photon Energy: extending from just above the ionization-threshold energy to 20 keV

(c) Source: Values computed by Trzhaskovskaya, Nefedov, and Yarzhemski [38, 39][5]

- Keys: Atomic Number, Subshell ID, Photon Energy (eV)
- Range: Atomic number: 1-99; Subshells: extensive; Photon Energy: extending from just above the ionization-threshold energy to 5 keV above threshold

8. Photoionization asymmetry parameter (PAP)

(a) Source: Calculations of Reilman *et al.* [40] for Mg, Al Kα and Zr Mζ

- Keys: Atomic Number, Subshell ID, Photon Energy (eV).

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[5] The authors would like to thank Prof. V. I. Nefedov (Institute of General and Inorganic Chemistry, Russian Academy of Sciences, Moscow, Russia) for providing his calculated photoionization cross sections for use in SESSA.

- Range: Atomic number: 1-96; Subshells: extensive; Photon Energy: Mg and Al Kα and Zr Mζ

(b) Source: Values computed by the program of Yeh and Lindau [37]

- Keys: Atomic Number, Subshell ID, Photon Energy (eV)
- Range: Atomic number: 1-96; Subshells: extensive; Photon Energy: extending from just above the ionization-threshold energy up to 20 keV

(c) Source: Values computed by Trzhaskovskaya, Nefedov, and Yarzhemski [38, 39]

- Keys: Atomic Number, Subshell ID, Photon Energy (eV)
- Range: Atomic number: 1-99; Subshells: extensive; Photon Energy: extending from just above the ionization-threshold energy to 5 keV above threshold

9. Electron-impact ionization cross section (EIICS)

(a) Source: Empirical expression of Casnati *et al.* [41]

- Keys: Atomic Number, Subshell, Electron Energy (eV)
- Range: Universal

(b) Source: Semiclassical expression of Gryzinski [42]

- Keys: Atomic Number, Subshell, Electron Energy (eV)
- Range: Universal

(c) Source: Empirical expression of Worthington and Tomlin [43]

- Keys: Atomic Number, Subshell, Electron Energy (eV)
- Range: Universal

10. Photoelectron line shape (XPL). Source: Binding energies of the elements [44].

- Keys: Atomic Number, Subshell
- Range: Atomic Number, Subshell: extensive

11. Auger electron line shape (AEL). Source: Energies and sensitivities calculated according to the *Z*+1 rule [4].

- Keys: Atomic Number, Subshell

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- Range: Atomic Number, Subshell: Limited by availability in data source

12. Fluorescence yield (FY)

(a) Source: Polynomial fit to empirical data for K-, L-, and M-shell fluorescence yields by Hubbell *et al.* [45]

- Keys: Atomic Number, Subshell
- Range: Universal

(b) Source: Semi-empirical expression for the K-shell fluorescence yield of Bambynek [46]

- Keys: Atomic Number, Subshell
- Range: Universal

(c) Source: Burhop's semi-empirical expression for the K-shell fluorescence yield [47]

- Keys: Atomic Number, Subshell
- Range: Universal

13. Auger backscattering factor (ABF). Source: Shimizu's formula for normal incidence of an electron beam on a homogeneous solid [48]

- Keys: Atomic Number, Subshell
- Range: Universal

7 TUTORIALS

In the present chapter, a small collection of SESSA CLI-files are presented and discussed. These files should help the reader to get acquainted with the most important features of operating SESSA. In addition, the tutorial sessions might be helpful to better understand some aspects of the surface sensitivity of electron spectroscopy for practical applications. These tutorials consist of a number of files residing in the indicated directories. In each of these directories, there is one file that has the same name as the directory and ends with the extension .ses. Loading this file will performs the tasks specified in all individual files in one file in one operation. The estimated computation times specified in the sections below are clock times measured when running the simulations on a 1.2 GHz Pentium PC [64].

7.1 Peak Intensities

7.1.1 Angular distribution of photoelectrons emitted from a homogeneous Au sample: Chandrasekhar's *H*-function

- Purpose: Getting acquainted. Performing a calculation of a photoelectron angular distribution and showing a comparison of results arising from different cross sections for elastic scattering.

- Time required for simulation: ~ 30 s

- Directory: tutorials\au-homo

- CLI-files (*.ses): ini.ses, sample.ses, spectr.ses, geo.ses, sla.ses, ta.ses, mott.ses, auhomo.ses

- GNUPLOT-files (*.g): compare.g

- Output-files (output*.*): sla_all.adf, ta_all.adf, es_all.adf

- Procedure:

  1. Start SESSA.

  2. Open the CLI-console window (CTRL-9 or choose Project/Command Line Interface from the Main menu). Click on the button Load Session and select the file ...\tutorials\au-homo\ini.ses. SESSA reads a number of commands from this file that initialize the software and sets a few preferences. Press CTRL-p to open the preferences menu. It is seen that the options Output/sample and Output/experiment have been deselected. This means that when SESSA writes output to a file, the corresponding information will not be included (see Section 4.3).

  3. Load the file sample.ses and open the "Sample/peak" menu (CTRL-1). It is seen that the sample is now assumed to consist of a semi-infinite piece of gold. The Sample/peak menu (CTRL-2) displays information on the signal electrons emitted from this sample for the given spectrometer and source settings. The Sample/Parameter"menu (CTRL-3) displays the corresponding parameters describing the electron-solid interaction. A right-mouse click on any of the numbers displayed here allows the user to change the database or view the reference for the value on display. Furthermore, the numbers can be changed by entering any value within a meaningful range. The database selection menu and reference dialog can also be invoked for a

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graphical representation of the differential elastic-scattering cross section and the differential inverse inelastic mean free path by means of a right mouse click. Furthermore, a double click on any of the graphical displays in SESSA transfers their contents to a separate plot window that provides features allowing a user to change the display, to plot the contents of the window to a postscript file, etc.

4. Load the file `geo.ses` and open the Experiment/geometry menu (CTRL-5). By choosing one out of the defined eight geometries from the Choose Configuration box, the selected information can be displayed or changed. SESSA will later do a separate calculation for each of the geometrical configurations shown here.

5. Load the file `spectr.ses` and open the Experiment/spectrometer menu (CTRL-6) to see that the spectrometer region has been set to a rather narrow energy range. Consequently, only the Au4f$_{7/2}$ peak is within the spectrometer energy window, as can be verified by pressing CTRL-2. It is seen that the Au4f$_{5/2}$ peak is also missing and that the asymmetry parameter for the Au4f$_{7/2}$ peak was set to zero for purpose of a model calculation. This choice was achieved by explicit commands in the file `spectr.ses` (press CTRL-9 to return to the CLI console and view these commands there).

6. Load the file `sla.ses` and open the Model Calculation menu (CTRL-7). A peak is on display here and the Straight Line Approximation box is checked. Furthermore the Auto box for number of collisions is deselected (and n_{col} is set to zero). The reason for setting n_{col} to zero is that we are presently only interested in the peak intensity of electrons that escape without inelastic scattering. By checking the Auto box for number of colisions, an entire spectrum is simulated instead of only the no-loss peak (although the spectrometer range would also have to be extended to lower kinetic energies in order to see any effect). The fact that the Straight Line Approximation box is checked means that SESSA assumes that the paths of the electrons in the solid are straight lines (i.e., elastic scattering of the signal electrons is neglected).

7. Load the file `ta.ses` and note that the simulation takes longer to converge now. Furthermore, the Transport Approximation box is now checked instead of the Straight Line Approximation box. This choice implies that elastic scattering is assumed to be isotropic and that the distance between successive elastic

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deflections is taken to be equal to the transport mean free path. Use of the transport approximation enables an analytic solution to be given for the angular distribution of photoemitted electrons (for emitters homogeneously distributed in a semi-infinite solid): the Chandrasekhar *H*-function [49]. Whenever the maximum number of collisions is set to zero and more than one geometrical configuration is defined, the partial intensities are displayed as a function of the configuration number (instead of the collision order) in the Sample/peak menu (CTRL-2) when Partial Intensities is selected for graphical display. The partial intensities are seen to decrease monotonically (within the precision of the calculation) when going to more oblique emission. This is the expected behavior for the *H*-function. To increase the precision of the calculation, decrease the convergence factor in the simulation menu (see Section 4.9).

8. Load the file `mott.ses`. Another simulation is performed that takes considerably longer. In this simulation, realistic (Mott) cross sections are used for the differential elastic-scattering cross sections [9, 10, 32-34, 62].

9. Start GNUPLOT and load the file `compare.g`. The result should resemble Fig. 7.1.

10. When working with CLI files, the order in which the commands are issued is important. For example, when `sample.ses` is loaded after `spectr.ses`, there will be two peaks in the considered region since the material is set in `sample.ses` and the command deleting the peak (and issued before in `spectr.ses`) will therefore be overruled. For user convenience, a file `au-homo.ses` has been included that runs all tests described in this section and should lead to the result shown in Fig. 7.1.

- Discussion:

The results shown in Fig. 7.1 provide a test for correct operation of a Monte Carlo simulation of electron transport in that the Chandrasekhar function represents the exact analytic solution of the emission problem for isotropic sources in a semi-infinite homogeneous medium and isotropic scattering. The *H*-function may be approximated by

$$H(\mu, \omega) = \frac{1 + \mu\sqrt{3}}{1 + \mu\sqrt{3(1 - \omega)}} \tag{7.1}$$
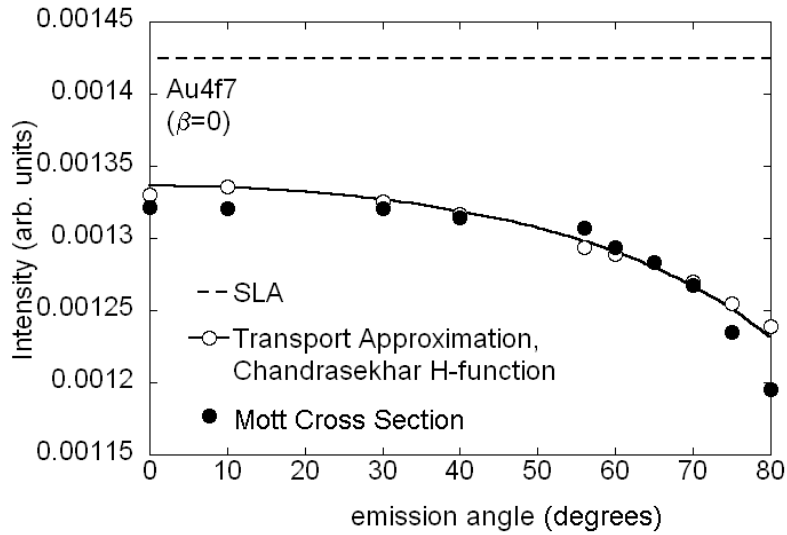
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Figure 7.1. Angular distribution of the Au $4f_{7/2}$ photoelectron peak intensity excited by Al Kα X-rays as a function of the polar emission angle (that is, as the sample is tilted). For model purposes, the photoionization asymmetry parameter was set to zero (isotropic emission). It can be seen from the open symbols that the SESSA results obtained in the transport approximation coincide with Chandrasekhar's *H*-function [49] represented by the solid line. This result is expected since the H-function is the exact analytic distribution for isotropic scattering. The solid circles show results from SESSA in which realistic (Mott) elastic-scattering cross sections were used. The dashed line shows results from the straight-line approximation (SLA) in which elastic scattering is neglected.

In this expression, $\mu = \cos\theta$, when θ is the electron emission angle with respect to the surface normal and ω is the single scattering albedo given in terms of the inelastic (λ_i) and transport (λ_{tr}) mean free paths as $\omega = \lambda_i / (\lambda_i + \lambda_{tr})$. The test is seen to be successful for SESSA. It is furthermore seen that the difference with the more realistic Mott cross section is not very significant. This result is explained by the so-called generalized radiative-field similarity principle [11] that specifies conditions for this similarity between isotropic and non-isotropic scattering to occur. It is also seen that the intensity at normal emission is decreased compared to the rectilinear-motion model where elastic deflections are completely neglected (SLA, Straight Line Approximation). See Ref. [50] for a more detailed discussion.

7.1.2 Angle-resolved XPS for a homogeneous Al sample

Purpose: Examine the effects of elastic scattering and of the acceptance solid angle of the analyzer

- Time required for simulation: ~ 30 s

- Directory: tutorials\al-anisotropy

- CLI-files (*.ses): ini.ses, sample.ses, spectr.ses, geo.ses, sim.ses, al-anisotropy.ses, infinite.ses

- GNUPLOT-files (*.g): compare.g

- Output-files (output*.*): sla_all.adf, ta_all.adf, es_all.adf

- Procedure:

The only difference from the procedure of Section 7.1.1 is that the three simulation steps are now executed in one file (sim.ses). The difference in the calculations is that the anisotropy of the photoionization cross section is not switched off: on the contrary, it is of main interest here. The specified geometries correspond to perpendicular irradiation of the back of a thin Al foil; the analyzer is again rotated around the sample covering a range of polar emission angles between -80 and 80^o. Note that a polar angle in SESSA is always specified by a positive number in the range 0^o to 180^o, as is usual in a spherical coordinate system; "negative" polar emission angles are obtained by changing the azimuthal angle by 180^o (see the file geo.ses for details).

- Discussion:

When core-level photoelectrons are liberated from an atom, the emitted intensity along the direction of the incident photons vanishes. In solids, however, a finite contribution in the forward direction is always seen. This is illustrated by the open symbols in Fig. 7.2 that represent the experimental data acquired by Baschenko *et al.* [51]. There are two reasons why a finite intensity is always observed in the forward and backward directions: first of all, the acceptance solid angle of the analyzer is finite, and, second, photoelectrons are scattered elastically by atoms in the solid. As a result, the elastic mean free path length may become comparable to the inelastic mean free path. Consequently, the signal electrons are efficiently scattered inside the solid and, even for an infinitely small analyzer acceptance angle, a non-vanishing intensity is expected in the forward and backward directions.

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The simulation results shown in Fig. 7.2 are consistent with the above interpretation in that, even in the rectilinear-motion model (curve labeled SLA), there is a finite probability for detecting electrons along the surface normal when the analyzer acceptance angle is finite. For an infinitely small acceptance angle, the intensity along the surface normal should be zero in the rectilinear-motion model, but not when elastic scattering is considered. SESSA is able to perform a simulation for an infinitely small acceptance angle of the analyzer by employing a symmetry property of the kinetic equation. Instead of simulating the trajectory from its generation point, tracing it through the solid, and hoping that it is emitted in the direction of the detector, its path is started in the analyzer and
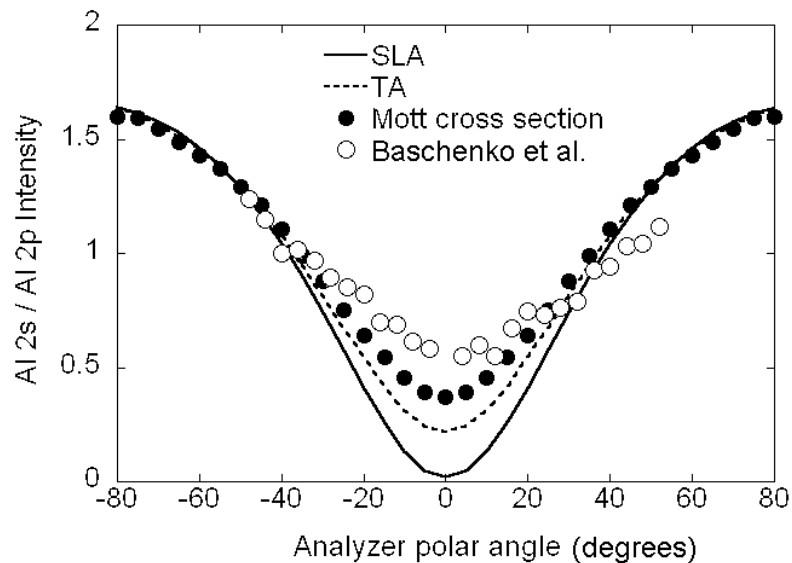

Figure 7.2. Ratio of the Al 2s and Al 2p photoelectron intensities as a function of the polar emission angle. Open circles: experimental results of Baschenko *et al.* [51]. Filled circles: SESSA simulation based on realistic (Mott) elastic-scattering cross sections. Dashed line: SESSA simulation based on use of the transport approximation (TA) in which an isotropic transport cross section describes elastic scattering of the photoelectrons. Solid line: SESSA simulation based on the straight-line approximation (SLA). In the experiment, the excitation was by Al Kα X-rays that illuminate the back side of a thin Al specimen. In the simulations, a semi-infinite Al specimen was irradiated with Al Kα X-rays at normal incidence. The polar acceptance half-angle of the analyzer was 6°. The fact that the analyzer acceptance angle is finite is responsible for a finite value of the plotted ratio at normal emission in the SLA.

traced back in reverse in the solid. In this way, every simulated trajectory contributes to the intensity simulated with the Monte Carlo method. This procedure was devised by Gries and Werner and has become known as "trajectory reversal" [8]. With the conventional MC calculation methods, it is strictly impossible to perform a simulation for an infinitely small acceptance angle. The reader may load the file `infinite.ses` to see how long it takes SESSA to converge to the same precision in such a case. Even for a moderately (but realistically) large polar acceptance angle of 6^o, conventional MC calculations take of the order of weeks to converge to the precision of the data displayed in Fig. 7.2.

7.1.3 Angle-resolved XPS for an oxidized silicon wafer with a carbon contamination layer

- Purpose: Illustrate the concept of chemical-state labeling using an important practical example. Demonstrate that consistency and accuracy of analysis can be considerably enhanced when different factors affecting the measured intensity are all accounted for simultaneously.

- Time required for simulation: ~ 30 s

- Directory: tutorials\sio2-c-arxps
- CLI-files (*.`ses`): ini.ses, sample.ses, peak.ses, geo.ses, sim.ses, sio2-c-arxps.ses

- GNUPLOT-files (*.`g`): compare.g

- Output-files (`output`*.*): sla_all.adf,es_adf.all

- Other files: seah.dat

- Procedure:

1. Load the file `sample.ses` and open the Sample/layer menu (CTRL-1). The compositional-depth profile is shown in the figure in the bottom-right corner. It is seen to consist of three layers: a substrate, a layer consisting of a Si-substrate and O, and a top layer consisting of C. Select the middle layer by clicking on it. This is equivalent to selecting layer 1 in the Choose Layer box in the top-left corner of this menu. It is seen that the Si component of the material constituting this layer is designated as [oxide]. The Si in the substrate has no chemical state attribute (as verified by clicking on the bottom layer). The chemical state attribute is a string of characters that can be freely chosen by the user and is not in any way interpreted by SESSA; it is only used to label the corresponding peaks. Press

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CTRL-2 to enter the Sample/peak menu to see the effect. Here, the silicon peaks appear double: as plain (elemental) silicon and one labeled as [oxide]. The important point is that these peaks are treated separately in the simulation.

2. Note that the density of the oxide was explicitly set with a corresponding command in the file sample.ses. This procedure is necessary because SESSA can only estimate the density of compounds, and such estimates may be in error by more than 100%.

3. Load the file peak.ses and open the Sample/peak menu (CTRL-2). It can be seen that different peak energies have been assigned to the two chemical states of Si: the separation of the peaks facilitates their differentiation in the simulated spectra (but this has no effect whatsoever on the simulated intensities).

4. Load the file geo.ses.

5. Open the Model Calculation menu (CTRL-7) and load the file sim.ses. Go back to the Sample/peak menu, choose Partial Intensities in the Choose data box of the graphical display, and inspect the result for the Si 2p and Si 2p [oxide] peaks. It is seen that the partial intensities for the two peaks vary differently with polar emission angle. The partial intensity for the substrate Si 2p peak decreases rapidly with increasing polar emission angle (i.e., as the average number of inelastic scattering events increases with increasing pathlength of the signal electrons in the overlayers as the sample is tilted). In contrast, the Si 2p [oxide] partial intensity does not change appreciably with emission angle.

6. Start gnuplot and load the file compare.g. The result should resemble Fig. 7.3.

• Discussion:

Angle-resolved XPS is an important technique in semiconductor technology for measuring oxide thickness and composition. In principle, the angular distribution of photoelectrons emitted from layered samples carries information on the compositional depth profile. However, there are limits to the amount of information that can be extracted from such data [53].

Experimental data are often analyzed on the basis of an approach in which elastic scattering of the signal electrons is ignored. Within this model, it is found that the intensity ratio of elemental (substrate) silicon
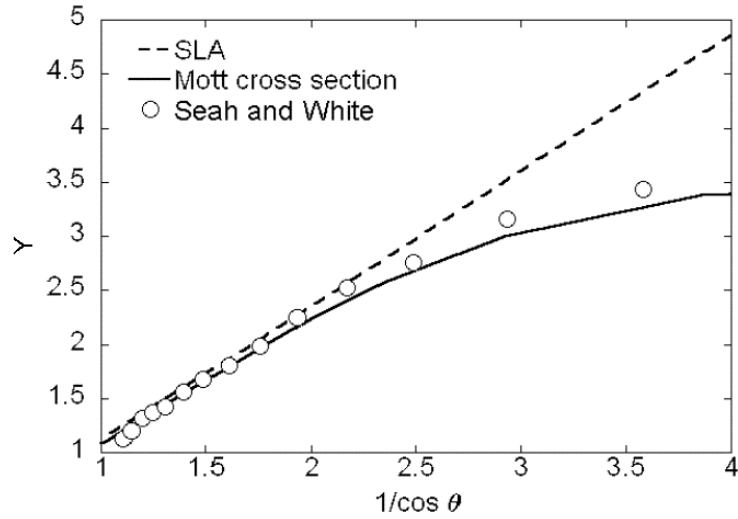
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Figure 7.3. A plot of Y from Eq. 7.2 as a function of $1/\cos\theta$, where θ is the electron emission angle, for angle-resolved XPS experiments with Si 2p photoelectrons from a thin SiO_2 film on a Si substrate. Open symbols: experimental data of Seah and White [52]; dashed line: result of SESSA simulations using the straight line-approximation (SLA); solid line: result of SESSA simulations based on Mott cross sections for elastic scattering.

and silicon bound to oxygen in a carbon-contaminated Si/SiO_2 sample is related to the oxide thickness d_{ox} as:

$$\frac{d_{ox}}{L\cos\theta} = \ln\left[1 + \frac{I_{ox}I_{sub}^{\infty}}{I_{sub}I_{ox}^{\infty}}\right] = Y , \qquad (7.2)$$

where L is the attenuation length for Si 2p photoelectrons in the SiO_2 film, θ is the polar emission angle (with respect to the sample normal), I_{ox} is the Si 2p intensity from the SiO_2 overlayer, I_{sub} is the Si 2p intensity from the Si substrate, and I_{ox}^{∞} and I_{sub}^{∞} are the corresponding quantities for bulk samples of SiO_2 and Si, respectively. Elastic-scattering effects and other phenomena that are not intrinsically accounted for in the approach of Eq. (7.2) are sometimes incorporated in the characteristic length L andthe value of $I_{sub}^{\infty}I_{ex}^{\infty}$. It is clear from Eq. (7.2) that a plot of Y (based on determinations of the four intensities in the logarithmic term) versus

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$1/\cos\theta$ will give the oxide thickness in units of *L* (if the plot is linear). It can be seen that the open circles in Fig. 7.3 based on the experimental measurements of Seah and White [52] lie close to a straight line through the origin for $(1/\cos\theta) < 2$ (i.e., $\theta < 60^{\circ}$).

One reason why the analysis based on Eq. (7.2) is so attractive is that the thickness of the carbonaceous contamination layer does not appear in it. In other words, the derived oxide-layer thickness for an arbitrary thickness of any carbonacaeous-contamination layer is independent of the thickness of this layer. On the other hand, for emission angles exceeding 60°, the effects of elastic scattering become quite significant, and the experimental points in Fig. 7.3 then deviate from the straight line expected from Eq. (7.2).

The data of Seah and White in Fig. 7.3 were acquired from experiments with a Si wafer. The results for $\theta < 60^{\circ}$ were analyzed with Eq. (7.2) to give a mean SiO_2 thickness of 39 Å.

Figure 7.3 shows SESSA results based on the Mott elastic-scattering cross section (solid line) and on the straight-line approximation (SLA) (dashed line). These results were obtained for a 36 Å oxide layer that gave the best consistency between the solid line and the experimental results. There is also reasonable agreement between the derived and reported oxide thicknesses. For emission angles exceeding 60°, the SESSA results with the Mott cross sections show the expected deviation from the dashed line from the SLA due to the effects of elastic scattering.

7.1.4 Depth distribution function (DDF) in XPS: comparison with experiment

- Purpose: Demonstrate that a quantitative model for the surface sensitivity in AES and XPS is implicitly contained in SESSA by comparing results for the Depth Distribution Function (DDF) with experiment.

- Time required for simulation: ~ minutes

- Directory: tutorials\ag2s-ddf

- CLI-files (*.ses): ini.ses, int.ses, mod.ses, mod_sla.ses, ddfini.ses, ddf.ses

- Output files (output*.*): es, sla, esddf, sladdf

- Other files: cleanup.bat, ddfcleanup.bat, zemek.txt

- Procedure:

1. Load the file `ini.ses` and open the Sample/layer menu (CTRL-1). If SESSA was started just before loading this file, a warning is displayed which explains that the density of the compound layer (Ag$_2$S) was only estimated. An appropriate command in the file `sample.ses` sets the density to a realistic value.

2. Leave the Sample/layer menu open and load the file `int.ses`. SESSA will perform a simulation of the intensity of the S 2s line as a function of the thickness of the Ag$_2$S layer. The change of the profile can be watched in the Sample/layer menu during the simulation.

3. Click on the file `cleanup.bat` (specific to this tutorial) in the ag2s-ddf directory. This operation deletes some unnecessary files in the output directory and merges the results of the simulation for the zero-order partial intensities into the files `es` and `sla`. The latter files contain the peak intensities calculated with SESSA that are displayed in Fig. 7.4(a).
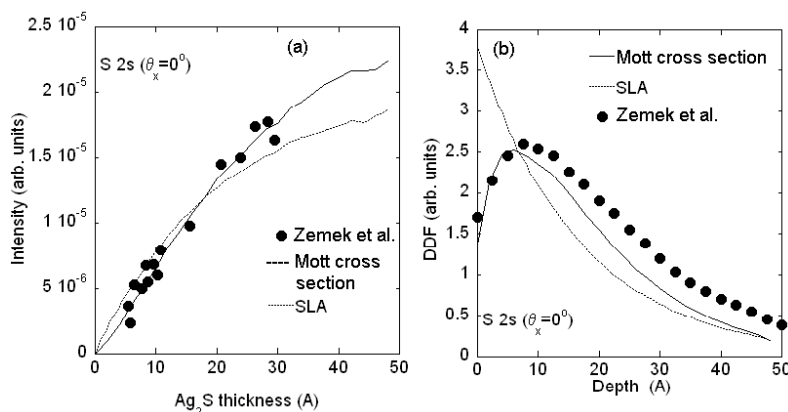

Figure 7.4. (a) Intensity of the S 2s XPS line as a function of the thickness of an Ag$_2$S overlayer on a Ag substrate that is irradiated with Al Kα X-rays. The photoelectrons are detected along the surface normal with an analyzer polar acceptance angle of 4.1°. Filled symbols: experimental data of Zemek *et al.* [54]; solid line: SESSA; dotted line: SESSA using the straight-line approximation (SLA). (b). Depth distribution function (DDF) for the experimental conditions in (a). Dotted line: evaluation of the experimental results in (a); Filled symbols: SESSA; solid line: SESSA with the straight-line approximation.

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4. Load the file `ddfini.ses` and open the Sample/layer menu (CTRL-2). The sample now consists of a 1 Å buried layer of Ag_2S between an Ag substrate and an Ag overlayer.

5. Leave the Sample/layer menu open and load the file `ddf.ses`. SESSA will perform a simulation of the intensity of the S 2s line as a function of the thickness of the Ag overlayer covering the 1 Å buried Ag_2S layer. The corresponding S 2s intensities as a function of depth closely match the depth distribution function.

6. Click on the file `ddfcleanup.bat` in the ag2s-ddf directory. This procedure deletes some unnecessary files in the output directory and merges the results of the simulation for the zero-order partial intensities into the files `esddf` and `sladdf`. The latter files contain the SESSA data for the depth distribution function displayed in Fig. 7.4(b).

*   Discussion:

Specification of the depth distribution function for a given surface electron-spectroscopy experiment represents the most general and comprehensive way to describe the surface sensitivity [55]. The zero-order depth distribution function, pertaining to the peak intensity of Auger electrons or photoelectrons that escape without inelastic scattering is defined as: "for electrons emitted in a given direction, the probability that the particle leaves the surface without being inelastically scattered from a specified depth measured normally from the surface into the material" [56].

Since the DDF can exhibit a quite complex behavior, it is not always possible to specify it in detail. Therefore, a number of quantities have been introduced that describe the major effect of the DDF on the surface sensitivity in a simple way. These quantities include the Attenuation Length, Effective Attenuation Length, Local Effective Attenuation Length, Practical Effective Attenuation Length, Information Depth, and Mean Escape Depth, and have recently been reviewed by Jablonski and Powell [57, 65, 66].

In Fig. 7.4(a), the experimental data of Zemek *et al.* [54] for growth of Ag_2S on a Ag substrate are compared with results of a SESSA simulation. In the experiment, a thin Ag foil on which the Ag_2S layers were grown was irradiated on the back side with Al Kα X-rays. The solid line is the simulated intensity as a function of the Ag_2S thickness when elastic scattering is accounted for; this line agrees quite well with the

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experimental results. The dashed line is the result from the straight-line approximation. In Fig. 7.4(b), the DDF derived from the experimental data is compared with the SESSA simulation results for the DDF. Again, a reasonable agreement between experiment and the simulation is seen.

The favorable comparison of the SESSA simulation data with experimental results demonstrates that SESSA is based on a realistic model for the surface sensitivity in electron spectroscopy.

7.1.5 Surface morphology: influence of surface roughness

- Purpose: To demonstrate that the intensity for rough samples decreases with increasing relative surface area.

- Time required for simulation: ~ 30 s.

- Directory: tutorials\roughness

- CLI-files (*.ses): ini.ses, sample.ses, mod.ses

- GNUPLOT-files (*.g): compare.g

- Output-files (output*.*): rgh

- Other files: wu.txt, rgh.txt, cleanup.bat

- Procedure:

1. Load the file ini.ses and open the Sample/layer menu (CTRL-1).

2. Load the file mod.ses and watch the ordinate axis of the plot window change when simulations are performed for different values of the relative surface area, indicating that the total measured intensity drops with increasing surface roughness.

3. Click on the file cleanup.bat thereby deleting unnecessary files in the output directory and creating the file rgh that may be edited to yield the file rgh.txt.

4. Load compare.g in GNUPlot to view the result (see Fig. 7.5).

- Discussion:

The comparison in Fig. 7.5 between SESSA simulation results and the experimental data of Wu *et al.* [58, 59] shows that the simple model for surface roughness implemented in SESSA provides a rough estimate for
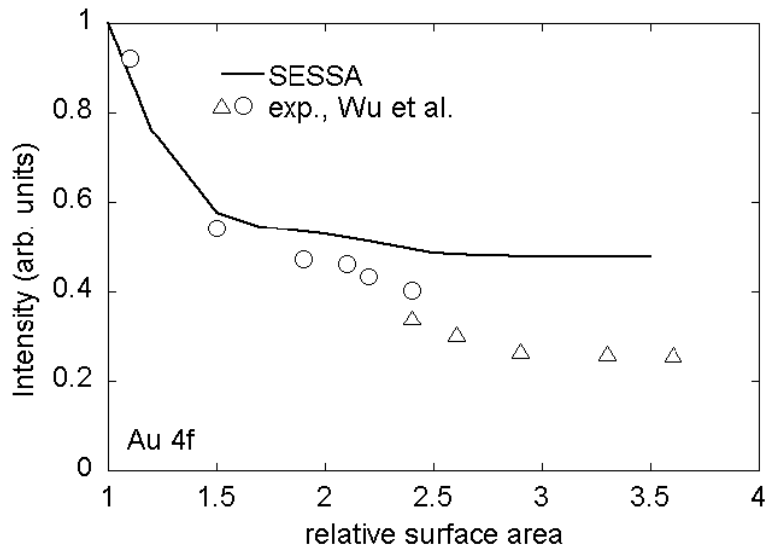
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Figure 7.5. Au 4f intensity as a function of the relative surface area. Data points: experimental results from Wu *et al.* [58, 59]; solid line: SESSA.

the effects of surface roughness on the signal-electron intensity. Note that for a realistically rough surface, the relative surface area assumes values between 1 and 1.2 (see Ref. [5]). Larger values of the relative surface area, such as those measured by Wu *et al.* for their samples, correspond to porous samples (so called high Brunauer-Emmet-Teller (BET) surfaces [60]).

7.2 Spectral Shape

7.2.1 Au overlayers on a Pb substrate: Spectral shape as a function of overlayer thickness and emission angle

- Purpose: Demonstrate the change of spectral shape with emission angle and as a function of the compositional depth profile.

- Time required for simulation: ~30 s.

- Directory: tutorials\spc

- CLI-files (*.ses): ini.ses, mod5.ses, mod25.ses

- GNUPLOT-files (*.g): compare.g

- Output files (`output\*.*`): *.spc

- Other files: cleanup.bat

- Procedure:

1. Load the file `ini.ses`.

2. Load the file `mod5.ses` that performs a simulation for a 5 Å thick Au overlayer on a Pb substrate for normal emission and for an emission angle of 60°. Subsequently, load the file `mod25.ses` that repeats the simulation for a 25 Å thick overlayer.

3. Load the file `compare.g` in gnuplot to view the results as displayed in Fig. 7.6.

- Discussion:

The results in Fig. 7.6 clearly show that the shape of the spectrum depends on the compositional depth profile of the sample. The same is
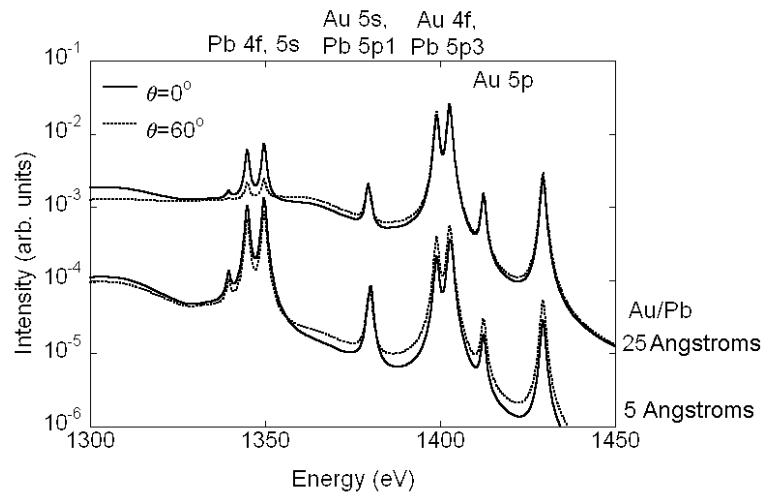

Figure 7.6. SESSA simulation results for the Au and Pb 4f, 5p and 5s spectral regions of two samples of Au overlayers on a Pb substrate and excitation by Al Kα x-rays. Upper curves: 25 Å Au/Pb; lower curves: 5 Å Au/Pb; Dotted lines: 60° emission angle; solid lines: emission along the surface normal.

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seen to be true for the relative intensities of the no-loss peaks. Furthermore, the variation of the spectral shape and the relative intensities with emission angle is different for the two depth profiles considered here. This result is in agreement with the expectation that the combined energy and angular distribution of the signal electron flux emitted from a sample carries information on the chemical composition of a specimen near the surface [13, 53].

7.2.2 Need for empirical data to realistically describe spectral shapes

Purpose: To show that incorporation of empirical data in SESSA provides a convenient tool for quantitative simulation not only of spectral intensities but also of spectral shapes.

- Time required for simulation: ~30 s.

- Directory: tutorials\aes-empirical

- CLI-files (*.ses): cu.ses, cu-emp.ses

- GNUPLOT-files (*.g): compare.g

- Output-files (output*.*):

- Procedure:

1. Load the file cu.ses and open the Model calculation menu (CTRL-7). The Al Kα Cu XPS spectrum is seen in this menu. Note that the LMM Auger part that is located in the range of kinetic energies between 700 eV and 1000 eV does not look very realistic. Go to the "Sample/peak" menu (CTRL-2) and click on any of the Auger peaks in the peak selection list. The graphical display of the intrinsic peak shape shows that the standard functional forms (Gaussian, Lorentzian, Doniach- Sunjic) do not resemble a realistic Auger peak (see Fig. 7.7).

2. Load the file cu-emp.ses and open the "Model calculation" menu (CTRL-7). Open the Sample/peak menu (CTRL-2) to see that all Auger peaks except one were removed. The remaining empirical Auger peak comprises a broad spectral range. In the Model calculation menu graphical display, a spectrum similar to the previous one is shown, but the Auger part now looks much more realistic, as shown in Fig. 7.7.
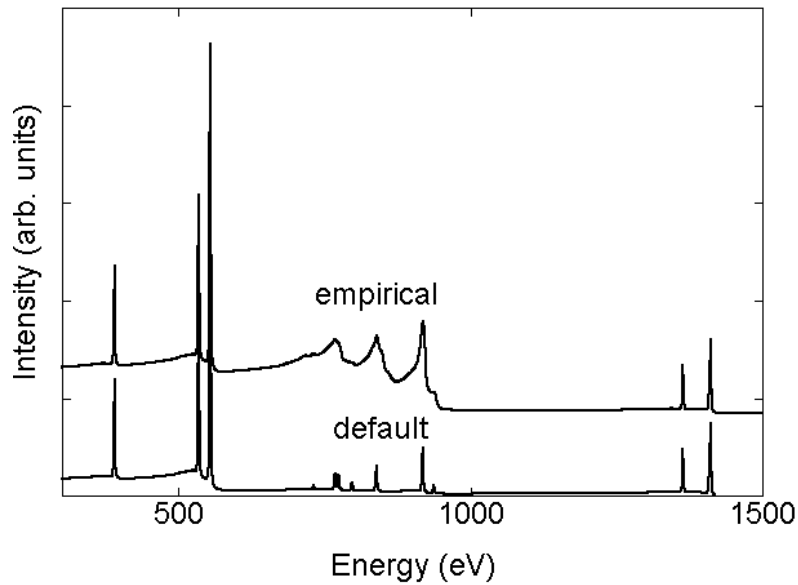
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Figure 7.7. XPS spectrum of a Cu sample excited by Al Kα x-rays. Upper curve: simulation result from SESSA using empirical data for the Cu LMM Auger transition; lower curve: the same simulation based on the default peak shapes contained in SESSA.

- Discussion:

A drastic difference is seen between the two spectra created by the above procedure (Fig. 7.7). However, comparison of the partial intensities of the Cu LMM peaks reveals that the spectral shape of the signal-electron sources is the only difference; the partial intensities are identical! To appreciate this, note that a simulation of a spectrum in SESSA proceeds in two steps: first, the partial intensities are calculated for a given sample, experimental conditions, etc. The partial intensities represent the number of electrons emitted from a given atomic subshell in a given atom that eventually reach the detector after experiencing a certain number of inelastic collisions. The parameters in the SESSA databases for this purpose are believed to be realistic. In the next step, the partial energy distributions are derived from the energy distribution at the source and the probability for an energy loss in an individual excitation (that is the differential inelastic inverse mean free path, DIIMFP). Although realistic data for the DIIMFP are available within SESSA for a limited number of materials for which detailed optical measurements are found in the literature, realistic data for the spectral shape of an Auger-electron

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transition and photoelectron transition are not presently part of the SESSA databases. This situation is particularly problematic for Auger-electron transitions, and emphasizes the necessity for empirical data when simulating the spectral shape.

7.2.3 Transfer of spectral data between different spectrometers

- Purpose: Demonstrate that intercomparison of spectra acquired on different instruments can be significantly facilitated when a flexible simulation tool is available that accounts for instrumental effects. In the present case, an effect of solid angle is studied.

- Time required for simulation: ~30 s.
- Directory: tutorials\transfer

- CLI-files (*.ses): ini.ses

- GNUPLOT-files (*.g): compare.g

- Output-files (output*.*): reg1.spc

- Procedure: Load the file ini.ses and open the Model calculation menu (CTRL-7). The graphical display in this menu is essentially the same as the results shown in Fig. 7.8.

- Discussion:

The results in Fig. 7.8 show that complex differences in spectral shapes can occur for instruments that differ in certain properties. In the present example, this concerns the solid angle of acceptance of the analyzer. This makes it very difficult to compare quantitative information on published spectra from different types of instruments. A simulation such as SESSA can help avoid such problems if instrumental effects on the spectral shape are realistically simulated.
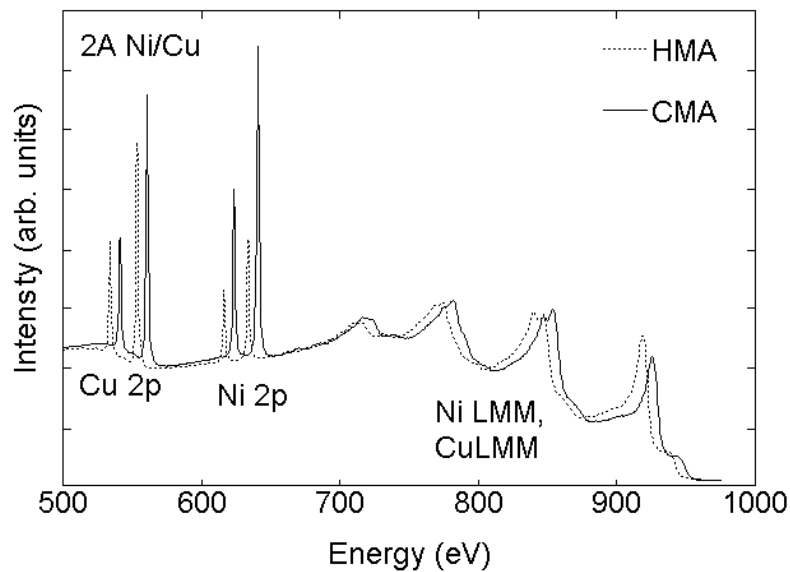
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Figure 7.8. XPS spectra of a 2 Å thick Ni layer on a Cu substrate excited by Al Kα x-rays. Dotted line: simulation results from SESSA assuming a hemispherical analyzer (HMA) for energy selection; solid line: SESSA simulation using a cylindrical mirror analyzer (CMA). To facilitate comparison, the two curves have been slightly shifted in energy relative to each other.

7.2.4 Handbook of simulated XPS spectra

- Purpose: Using the extensive databases in SESSA and the flexibility offered by the CLI, it is possible to produce large customized reference data sets.

- Time required for simulation: several minutes.

- Directory: tutorials\handbook

- CLI-files (*.ses): ini.ses, handbook.ses, handbook-brief.ses, dosim.ses

- Output-files (output*.*): XPS spectra of elemental solids throughout the periodic system, with and without a 5 Å thick carbon contamination layer.

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- Procedure:

1. Load the file `ini.ses.`

2. Load the file `handbook_brief.ses` to get a quicker impression of what `handbook.ses` does when you start it.

3. Edit the file `dosim.ses` and uncomment the indicated line.

4. Run the file `handbook_brief.ses` again, now producing a handbook of XPS spectra recorded on samples with a 5 Å carbon contamination layer.

- Discussion:

The above CLI files produce two extensive reference data sets for a collection of elemental solids throughout the periodic table. In the second run, a systematic change in the experimental conditions is simulated by adding a 5 Å thick carbon-contamination layer to each sample.

7.3 Techniques other than conventional AES/XPS

7.3.1 Total Reflection XPS (TRXPS)

- Purpose: Illustrate the fact that the surface sensitivity is generally determined by both the excitation depth distribution as well as the emission depth distribution function.

- Time required for simulation: ~30 s.

- Directory: tutorials\trxps

- CLI-files (*.ses): sample.ses, xps_sim.ses, trxps_sim.ses, trxps..ses

- GNUPLOT-files (*.g) :

- Output-files (output*.*): xpsreg1.spc, trxpsreg1.spc

- Procedure:

1. Open the Sample window in the GUI and press CTRL-I to load the session file `sample.ses`. After a while, the structure of the sample is updated on the screen and is seen to consist of a very thin C-
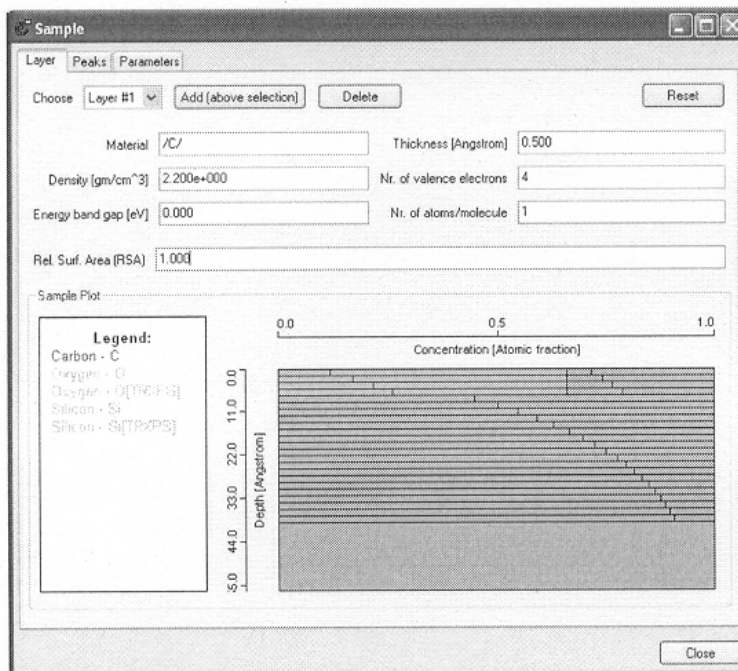
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Figure 7.9: The Sample/Layer menu in the GUI showing the excitation depth distribution in TRXPS after loading the file `sample.ses`.

contamination layer (layer 1, 0.5 Å) on top of 8 Å of SiO_2 on an Si substrate (see Fig. 7.9). The upper 24 layers are seen to consist of a contribution labeled [trxps] and a normal unlabeled contribution. The concentration of the species labeled [trxps] decreases exponentially with depth. In the Sample/Peak menu, it can also be seen that each peak appears in duplicate, unlabeled as well as labeled. These settings were chosen to mimic a total-reflection XPS experiment, where the incidence angle of the exciting x-radiation is chosen close to the critical angle for total reflection, leading to a dramatic decrease of the characteristic length (or depth) for creation of photoelectrons. In the present example, this characteristic length was arbitrarily chosen to be 20 Å, a typical value in TRXPS.

2. Next, load the file `xps_sim.ses`. This file performs a simulation for *all* peaks (labeled as well as unlabeled), and writes the corresponding output into the directory output. Since the labeled and unlabeled peaks have the same peak shape and energy, they are added in the resulting spectrum `output\xpsreg1.spc`. Thus the
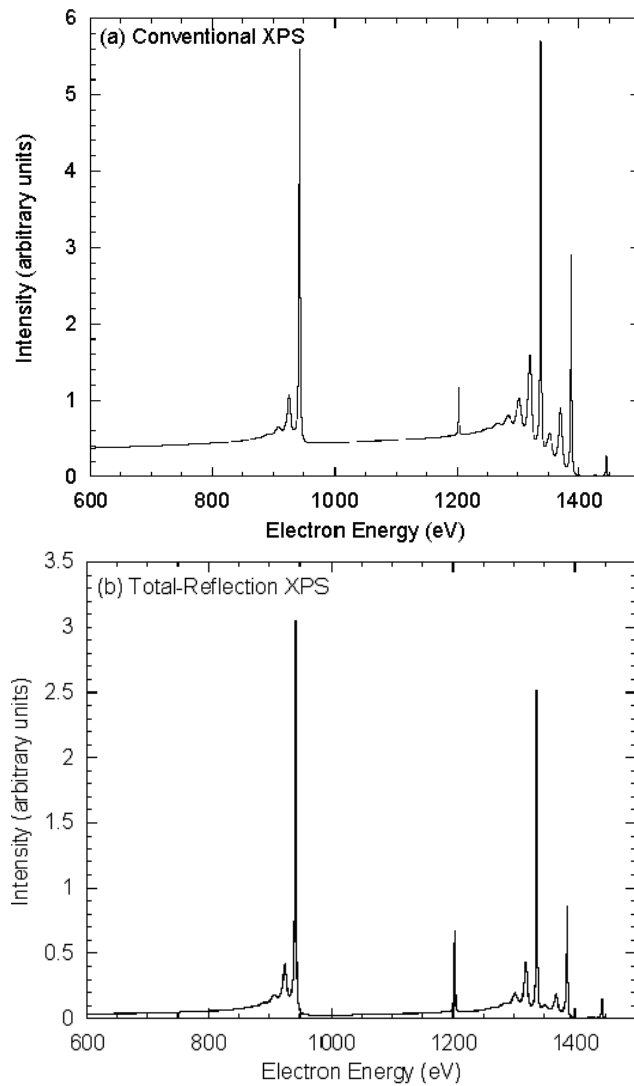
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Figure 7.10. Simulated spectra of a sample consisting of a 0.5 Å thick C-contamination layer on top of a 8 Å thick SiO_2 layer on a Si substrate. (a) Simulation of a conventional XPS spectrum; (b) total reflection XPS spectrum, where the angle of incidence of the x-rays is close to the angle for total reflection.

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3. When the file `trxps_sim.ses` is loaded next, the same simulation is repeated but the unlabeled peaks are deleted from the spectra prior to the simulation. In consequence, the resulting spectrum `output\trxpsreg1.spc` now corresponds to a depth distribution of excitation for the species labeled [trxps] only. The result is displayed in Fig. 7.10(b). The inelastic background is seen to be significantly decreased, indicating that the surface sensitivity of this spectrum is higher than for a conventional XPS measurement.

4. It should be noted here that, in these simulations, the incidence direction of the x-rays was chosen along the surface normal, as was the detection direction. In other words, the change in the surface sensitivity due to the grazing incidence of the x-rays was simulated only by taking into account the depth distribution of the excitation. For a more realistic simulation of TRXPS with the present version of SESSA, it is imperative to properly account for the experimental geometry since the relative peak intensities for photoelectrons with different asymmetry parameters depend sensitively on the values of this parameter, in particular for typical TRXPS geometrical configurations. It is easy to perform realistic simulations with SESSA; one merely has to specify the correct geometrical configuration in the Geometry menu. Since the example studied here merely serves illustrative purposes and is not compared with actual experimental data, the simulations were performed for the default geometrical configuration.

- Discussion:

In surface analysis techniques employing particle beams, the analyzed depth range is generally determined by the penetration of the exciting radiation into the surface, described by the so-called excitation depth distribution function $\phi_x(z, \theta_x)$, the depth distribution of species leading to the generation of the detected signal $c(z)$, and the probability for escape as a function of the depth. In electron spectroscopy, it is convenient in this connection to introduce the partial intensities of electrons that reach the detector after participating in a given number of scattering events C_n. The escape probability for n-fold inelastically scattered electrons is described by the partial escape distributions, or depth distribution functions $\phi_{e,n}(z, \theta_e)$. Then the partial intensities are given by:

$$C_n(\theta_x, \theta_e) = \int_0^\infty \phi_x(z, \theta_x) c(z) \phi_{e,n}(z, \theta_e) dz \qquad (7.3)$$

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where the subscript *x* represents the excitation process and the subscript *e* denotes the emission process. The excitation depth distribution function can be described in terms of a Beer-Lambert attenuation law:

$$\phi_x(z, \theta_x) = \exp(-\mu_x \rho z / \cos \theta_x) \qquad (7.4)$$

where μ_x is the mass absorption coefficient determining the relevant excitation range (measured along the photon trajectory) and ρ is the mass density of the material. The characteristic length of the emission depth distribution function is approximately given by the inelastic mean free path λ that is orders of magnitude smaller than the x-ray absorption length ($\lambda \ll 1/\mu_x \rho$) for conventional XPS. In this case, the variation of the excitation depth distribution with depth in the integral (7.3) can be neglected and the surface sensitivity of XPS is entirely determined by the escape process.

When the angle of incidence of the x-rays is close to the critical angle for total reflection $\theta_{x,c}$, the characteristic length for the excitation process becomes comparable to the inelastic mean free path [61], and an angular variation of the (glancing) incidence angle according to Eq.(7.3) allows probing of different depth regions by effectively changing the excitation depth distribution experimentally.

In this case, the detected photoelectrons mainly escape from shallow depths (as indicated by the depth distribution of the species labeled [trxps] in the Sample/Layer menu), and consequently the higher order partial intensities that make up the inelastic background are suppressed since the emission depth distribution function for increasing order of scattering samples increasingly larger depths (approximately $n\lambda_i / \cos \theta_e$ for *n*-th order scattering [13]). This explains the reduced inelastic background seen in the TRXPS spectrum in Fig. 7.10(b).

7.3.2 Ion-induced Auger-electron emission

Purpose: Demonstrate that the source depth distribution can be specified in a flexible way using a technique involving chemical-state labeling.

- Time required for simulation: ~35 min.

- Directory: tutorials\ion-induced

- CLI-files (*.ses): sim.ses, geo.ses, cu.ses

- GNUPLOT-files (*.g): pi.g,spc.g

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- Output-files (`output\*.*`): cucuLM9_emitting.*

- Other files: CULMM.REG

- Procedure:

Start SESSA.

1. Open the sample menu (CTRL-5). Load the file `cu.ses` and wait a moment. The commands in this file set up a depth profile of emitters distributed with a Gaussian profile at 12 Å mean depth and a full width at half maximum intensity of 5 Å. This profile is assumed to be caused by energy deposited in the solid by some kind of incident particle (e.g., ions) and the energy deposition profile is assumed to be related to the depth profile of Auger electron emission. The profile is seen in the sample menu after SESSA has processed the commands in this file. By clicking on the various layers in the depth profile and observing the material box in the sample GUI menu, it is seen how the chemical state labeling can be used to specify a depth profile of emitters in a flexible way.

2. Load the file `geo.ses`. This sets up the geometry: the analyzer is rotated around the sample surface normal in the range between 0^o and 60^o.

3. Load the file `sim.ses`. SESSA performs a simulation of the spectrum for the specified geometries. Open the simulation menu (CTRL-7) before or after loading `sim.ses` to see the simulation results.

4. Open the Sample/Peak menu and choose "partial intensities" in the display selection box to view the partial intensities. You may wish to double click on this window to transfer its contents to the separate plot window that can be enlarged to fit the screen, improving clarity.

- Discussion:

Figure 7.11 shows the result of the simulation. It is seen that both the peak height and shape depend on emission angle. Inspection of the partial intensities reveals the reason for the dependence of the peak shape on the emission angle: for more oblique emission, the signal electrons have to travel a longer distance through the solid, thereby
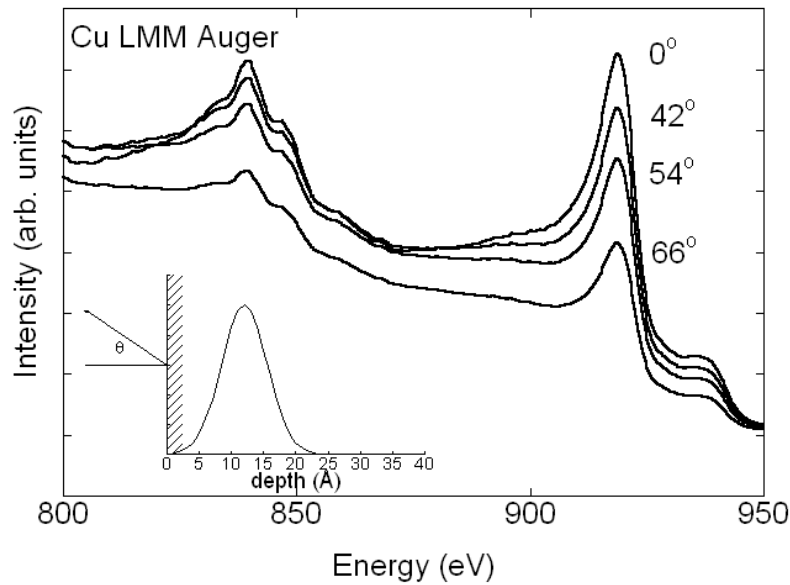
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Figure 7.11. Cu LMM Auger spectra for different emission angles and for the source depth distribution shown in the inset. These results simulate ion-induced Auger electron spectra.

increasing the probability for an energy loss. In principle, measurements of the angular distribution of the peak shape contain information on the emission depth distribution function (EDDF). However, it is difficult to rigorously retrieve EDDFs from such measurements. Simulations that optimize the consistency between experiment and theory by varying the depth distribution of the emitters provide a straightforward means of obtaining at least a rough impression of the EDDF.

8 GETTING HELP, TESTING AND DEBUGGING

8.1 Getting Help

Online help is provided by SESSA in the GUI and in the CLI. In the GUI, selecting Help in the main menu and then selecting SESSA help invokes Adobe Acrobat Reader or other software to display PDF files. Most of the text from this Users' Guide present will then be displayed on the screen, together with bookmarks and thumbnails that facilitate navigation through this documentation.

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In the CLI, typing HELP in any scope produces corresponding help messages. This can also be achieved by opening the command syntax tree in the CLI console by clicking on the button Command List and clicking on the command in the list for which information is desired.

8.2 General Information

The second option in the Help menu is the About Box and the disclaimer box. The disclaimer box displays the message that can also be found on page iv of this manual. The About box provides some general information on the history of SESSA and acknowledges software resources that were helpful in its development. The latter comprise:

- NetCDF: http://www.unidata.ucar.edu/packages/netcdf/
- wxWindows: http://www.wxwindows.org/
- CVS: http://www.cvs.org/
- Inno Setup: http://www.jrsoftware.org/isinfo.php
- SCITE: http://www.scintilla.org/SciTE.html
- Free Borland C++ 5.5 Compiler: http://www.borland.com/
- GNUPlot: http://www.gnuplot.info

The authors gratefully acknowledge the use of these resources for the development of SESSA [63].

8.3 Testing and Debugging

Given the complexity of the software, SESSA has been developed by a very small team (see the About box). For successful testing of the software, it was considered essential to involve a larger group of users. To facilitate reporting of bugs and the exchange of information on SESSA, a world-wide-web interface was set up which is explained in the present section.

The option Submit bug in the Help menu is used to report bugs in the operation of SESSA. The user's selected world-wide-web browser will then open the page (http://www.iap.tuwien.ac.at/~werner/SESSA.htmlx). A registered user[6] can now choose SESSA bug reports that will open up the SESSA bug survey page, where all bugs, features and suggestions are collected and discussed by the community of testers and users. The password assigned when registering as a user will be needed at this stage. In order to facilitate effective communication, it is essential that a user identifies the appropriate software subsystem when sending

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[6] A user wishing to report a bug should send an email to sessa-test-request@iap.tuwien.ac.at with the text "SUBSCRIBE" in the body of the message.

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comments. Furthermore, if possible, a check should be made to determine whether the same comment has been made previously. For this purpose, several facilities have been set up.

Any reported comment is categorized according to the report class and the software subsystem. Three report classes are dealt with presently: bugs, bug features, and suggestions.

- Bug: An error in the logic of the program that leads to incorrect results or to a crash of the program.

- Bug-feature: An error in the logic of the SESSA-user interaction that does not lead to incorrect results or to a crash of the program, but makes it very hard to operate the program properly since the rules of operation for a particular feature are unclear.

- Suggestion: Any suggestion for improvement of style, functionality, etc. of SESSA.

The software subsystems for which reports can be maintained comprise:

1. CLI-Command-Line-Interface
2. PRO-Project/Main-menu
3. PLO-PlotWindow
4. PRE-Preferences
5. LAY-Sample/Layer
6. PAR-Sample/Parameters
7. PEA-Sample/Peak
8. SOU-Experiment/Source
9. SPE-Experiment/Spectrometer
10. GEO-Experiment/Geometry
11. DAT-Databases
12. MOD-Model
13. TUT-Tutorials
14. MIS-Miscellaneous

After deciding on the class and subsystem according to which the observed behavior of SESSA should be categorized, the corresponding box on the main SESSA debug page should be checked. This will open the page specifically dedicated to the bug associated with the chosen report class and software subsystem. Here, a list of the reported errors is displayed. Every item in this list corresponds to an individual bug. All the comments collected for this bug so far can be viewed by clicking on the option Go to the list of comments for this bug. If a user wishes to add a comment, the option Submit a comment to the list of previous comments may be chosen. The local email program will pop up with an appropriate address to submit the comment.

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If, after inspecting the list for the given class and subsystem, a user concludes that a particular error is not present in this list, the option I found a NEW feature/bug in the Databases subsystem of SESSA should be selected at the top of the page to report a bug not previously listed. The local email program will pop up with an appropriate address. A brief explanation of the observed bug should be given in the body of the message. Furthermore, the following message will appear in the body of the message: "Please attach debug.ses/debug_crash.ses/debug_last.ses (location: SESSA binaries)". This message prompts a user to attach any of these files that are present when submitting the bug report.

During a SESSA session, a file `debug.ses` is written that contains all commands issued. If the program terminates properly, this file is renamed to `debug_last.ses`. If the program crashes, the file `debug.ses` contains all commands necessary to analyze the problem at hand. If SESSA is run again after the crash, this file is renamed to `debug_crash.ses`. To facilitate analysis of the reported bug, it is essential that the tester attach any of the above files that are present in the directory where the SESSA binaries reside. To ensure that these files are up to date, a bug should always be reported as soon as possible after it was encountered. If the program crashes it should be started again and a bug report should immediately be sent. If the program is still active, the Submit bug option in the Help menu should be chosen and the bug should be reported accordingly

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9 CONTACTS

If you have comments or questions about the database, the NIST Measurement Services Division Standard Reference Data Program would like to hear from you. Also, if you have any problems with the disk or installation, please let us know by contacting

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